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microthrusters which	produce the very sma	11 minimum impulse b	its (MIB) needed to
plasma thruster (UIDM)	e satellites did not	exist before we devel	oped our micro laser
engine which uses a hi	. The μ LPT is an effigh brightness semicond	cient, long life, low	-thrust pulsed rocket
energy. It uses a sim	ple low voltage semicond	nuctor or glass liber	laser as a source of
using any electrical n	power in the off state.	A lens brings the las	ve the laser without
target within a very s	mall spot, producing a	spark or miniature ie	t. Which provides the
impulse. Advantages of	the LPT relative to ot	her engines are:	o, willow provided the
1. Specific impulse up	to 2,000 seconds, muc	h larger than competing	ng techniques because
of the high tempera	ture produced by the fo	cused laser	
2. The smallest minimum	m impulse bit (MIB) of	any thruster: 1 nano ne	ewton-second
bits:1)	ing range for impulse g	enerated by a single de	evice (100,000
•	orce range in a single	device	
Potential total mass of	f a few ounces arising	from the smallness and	simplicity of the
operating parts of the	engine.		
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1. Overview of the LPT Program

1.1 Executive Summary

Commercial, scientific and military communities who field Low Earth Orbit (LEO) Satellites are now moving toward the concept of micro- and nano-satellite constellations, in which advancing technology permits linking networks of numerous, very small satellites to take the place of expensive, very large satellites. In many cases, due to their distributed nature, these constellations can accomplish tasks that could not be performed by single large spacecraft. Micro- and nanospacecraft will be from 100kg to as little as 1kg mass.

However, microthrusters with very small minimum impulse bits (MIB) needed to accurately point these satellites did not exist before we developed our laser plasma thruster (LPT) in Phase I.

The µLPT is a low mass, efficient, long life, micro-thruster for microsatellites which uses a high brightness semiconductor or glass fiber laser as a source of energy. It uses a simple low voltage semiconductor switch to drive the laser without using any electrical power in the off state. A lens brings the laser light output to a target within a very small spot, producing a spark or miniature jet. which provides the thrust. Figure 1 shows how the device works.

Advantages of the LPT relative to other engines are:

- 1. Specific impulse (related to exhaust velocity) larger than competing techniques because of the high temperature produced by the focused laser
- 2. The smallest minimum impulse bit (MIB) of any thruster: 1 nano newton-second
- 3. A very large operating range for impulse generated by a single device (100,000 bits:1)
- 4. A nearly infinite force range in a single device
- 5. Potential total mass of a few ounces (to be demonstrated in Phase II), arising from the smallness and simplicity of the operating parts of the engine
- 6. Potential applicability to orbit raising in a higher power version.

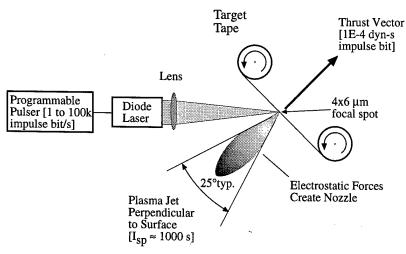


Fig. 1. Illustrating the Laser Plasma Thruster (LPT)

year, changes the position of the 10-kg satellite by 3km.

typing paper. Yet, such an MIB requirement is realistic. For a 10-kg, 20-cmradius satellite at 500km altitude, ±1bit applied as torque controls drift of the center of its field of regard on the ground to ±5m/s. Applied in translation

The MIB discussed in the

USAF requirement for this task

(to which our Phase I project

responded) is 1 nano newton-

second [1E-4 dyn-s]. This is an impulse ten times smaller than

the momentum of a flying

mosquito. Applied at 500Hz, such an impulse would just levitate a 1mm diameter dot of

for stationkeeping, 1 bit gives a velocity change which, after a

Our 1-watt LPT now generates 0.1 mN force; a 10-watt version of the Phase II engine will generate 1 mN, which is sufficient to raise a 10-kg LEO satellite 500 km in 30 days.

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Scaledowns of conventional thruster designs to very small physical scale have been proposed to generate micro-impulses. Examples are miniature chemical rockets, pulsed gas thrusters, ion drives, plasma jets and "resistojets", which use the same principle as do inkjet printer heads.

However, behavior of these engines at small scales is not predicted by behavior at large scales. See § 1.3 below for a complete discussion of these effects.

We proposed, and have now proved in Phase I, this new technology for satellite orientation and propulsion, in which thrust is generated by the ablation jet produced by a focused, pulsed semiconductor laser. Thrust is always normal to the target surface. No nozzle is required to form the jet. Published data [see e.g. Phipps and Dreyfus 1993] shows that plasma electrostatic forces constrain the jet into a well-directed lobe. No new physics is required to understand very small scale operation at the 5µm-diameter focus. The laser energy required to produce a given impulse is well understood, based on our previous reported work. Electrical efficiency and specific impulse I_{sp} are similar to that of pulsed plasma thrusters (PPT's), but the LPT is much simpler and potentially much smaller, like a TV remote control. Its electrical pulser needs only produce logic-level voltages rather than kV. It uses no power when it is not "on". It can make a 100µs thrust pulse, anywhere from once a month to thousands of times a second, or it can simply be "on" all the time. Another plus is long life - the laser can easily outlast the satellite, and the precious "fuel" for the tiny rocket is used efficiently by heating it to high temperature during each spark.

We measured I_{sp} as large as 1,800 seconds in the engine's output midrange. Even at 1 MIB output, we measured I_{sp} up to 350 s. Limited by the 1 watt peak deliverable power of the Phase I diode, $I_{sp} = 300$ s can be considered typical. In other work, the author has measured specific impulse $I_{sp} = 7,000$ s using more powerful short-pulse lasers [Phipps and Michaelis 1994].

We measured momentum coupling coefficients (ratio of momentum produced to incident laser energy) C_m up to 25 dyn-s/J. This is among the largest values ever reported in the ablation

literature for simple homogeneous materials. $C_m=10$ dyn-s/J was typical for our targets.

The ratio between the largest impulse we observed with our engine and the smallest in a single shot is 4.6 decades, from 16 kbits to 0.4 bits, as we varied laser pulsewidth from 100 µs to 300 ms.

Lacking the <u>target transport mechanism</u> to be developed in Phase II, we did not make measurements of force in continuous operation. However we did observe the engine working at 1kHz. Implicitly, we achieved 5.1 decades in force dynamic range during 1 second with a single LPT – 16 kbits/pulse at 3.3 Hz with 300ms pulsewidth (cw operation) vs. 0.4 bits/pulse at 1Hz. It is obvious that the LPT's force dynamic range can be nearly infinite depending on how infrequently the small impulse is applied. The maximum continuous force output from our 1-watt engine as configured for Phase I is 10 dyn or 0.1 milli-newton.

The plume produced by the LPT is a directed jet of atomic vapor or plasma rather than a cloud of chemical compounds

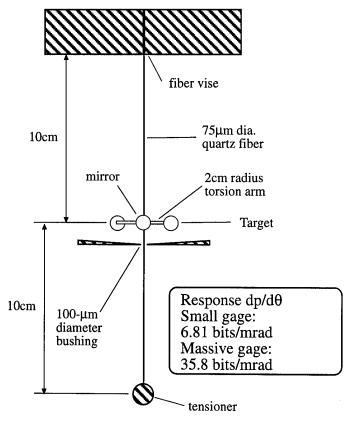


Figure 2: The torsion microbalance

which can condense on spacecraft optics, due to the high temperatures of the laser-surface interaction. We have observed no clouding of the target illumination optics during thousands of shots.

The most difficult part of this project was not making the thruster, but measuring impulses as small as 1 nano newton-sec. In order to measure the tiny impulses made by our microthruster, we built a torsion microbalance [Figure 2], using a glass fiber about the size of a human hair. The mirror shown deflects a monitor laser beam to a video station up to 3.4 meters distant for the most sensitive measurements. In this configuration, we sometimes have to wait during measurements while traffic finishes passing on the road 100 yards from the laboratory. Footsteps on the concrete floor next to the apparatus disturb it. A microscope inside the vacuum test chamber is used to position the target and determines the focused spot size on target.

1.2 How Laser Ablation Thrusters Work

Laser ablation [Dreyfus et al 1993] is the process by which a laser heats a solid surface sufficiently to eject atoms from the surface and is an important tool in microelectronics. This process is more complex than boiling a block of ice with a welding torch, in that "phase explosion" produces a jet of very hot vapor. The most momentum per joule of laser light is produced at or just beyond the threshold intensity for plasma formation. The nearly diffraction-limited beams of these new flare-type laser diodes can be focused to $5\mu m$ diameter at full-width half maximum (FWHM) with readily available lenses, so that 1 watt of laser power produces 1 MW/cm² on the target.

Table 1: Comparison of Micro-Thruster Types[VL = Very Low, L = low, M = moderate, H = High, VH = Very high, EH = Extremely high]

Micro Thruster Type	Efficient Working Range	Operating Cost/Bit	"Fuel" Cost	Energy Efficiency	Relia- bility	Life in Use	I_{sp}
Laser	H	L: 1 device covers 5 decades	V L	H	VH	VH	1,000
Chemical	L	L - if batch fabricated	M	L	L - if High I _{sp}	1 shot	200
PPT	M	L - if batch fabricated	M	Н	M	M	3,000
Gas Jets		L - if batch fabricated	Н	L	Н	L	100
Resisto- jets		L - if batch fabricated	M	L	M	M	50
Ion engines	M	Н	L	Н	L	M	5,000

1.3 Enabling Developments & Technologies

Laser ablation thrust has been proposed and seriously considered for a number of space applications during the past decade [Phipps and Michaelis 1993, Phipps 1992]. Several specific events in the past year have made on-board laser microthrusters the most compelling of these:

a) The availability of flare-type AlGaAs-based, single transverse mode semiconductor diode lasers [Figure 3] with brightness

$$B = \frac{P}{\lambda^2} = 230 \frac{MW}{\text{cm}^2 \text{sterrad}}$$
 [1]

These currently have an output of about 2 watts of nearly diffraction-limited power [Lang, et al. 1998] in the near-IR (970-nm wavelength) region. We realized that this brightness was adequate for the first time to enable rocket-like laser ablation thrust on a small scale from the spark formed by tightly focusing this beam on a solid surface in vacuum. Previous diodes were more than 100 times less bright, requiring kilowatts instead of watts to make the spark. Kilowatt-size diode bars and their power supplies are definitely too heavy and power hungry for microsatellites.

- b) The development of such lasers with 35% electrical efficiency.
- c) The routine focusing of such lasers to input 80% of their energy into a 6- μm diameter aperture for fiber-optics work.
- d) Demonstration of mean-time-between-failure (MTBF) of 1 million hours in such lasers In contrast, there are obvious problems with scaling down the pulsed plasma thruster (PPT), microchemical thruster and other conventional engine types to microscale.

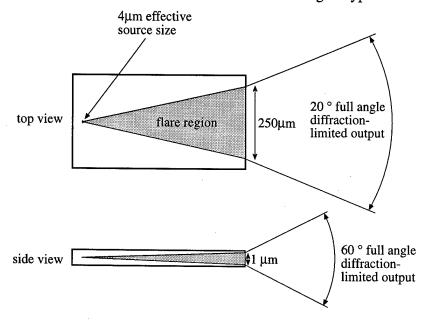


Fig. 3. The Flare-type, High Brightness Diode Laser

chemical thrusters and micro PPT's.

- Some of these problems are:
- a) New physical regimes are entered when characteristic dimensions of the nozzles in such devices are so small that gas flow no longer can characterized by the theory of viscous fluid flow. The assumption of a continuum on which fluid dynamics is based disappears when the mean free path is no longer much smaller than nozzle diameter. For a 1µm nozzle, this assumption is strongly compromised at 10 bar pressure.
- b) Further, boundary layer effects become dominant in μm-scale nozzles, an important complication for pulsed gas jets, micro
- c) In the case of micro PPT's, breakdown thresholds are not tabulated for such small electrode separation and not easily extrapolated from existing data. PPT's also have the problem of large high voltage power supplies.
- d) There is no technology other than the LPT which has demonstrated such a small MIB.

In order to reach the intensities required to produce plasma on a surface with a 1-watt laser, it is necessary to create small focal spots, ranging from 5µm to 200µm depending on the laser pulsewidth being used. We had peak intensity up to 1MW/cm² and fluence (energy density) up to 300 kJ/cm² available on target for our tests. Creating the smallest spot size, important for

producing small impulses, is not simple, but not as demanding as the technology routinely used to read the dots on a CD.

For midrange and large impulses, we found the spot size not to be very critical.

2. Technical Objectives

The objectives in our Phase I statement of work are:

- a) Measure very small impulses at the level of 1E-4 dyn-s during 100µs with 10% accuracy, design and build impulse gage and calibrate it in the vacuum chamber.
- b) Demonstrate a dynamic range of 100,000 from about 1 bit/s in a single LPT.
- c) Match the impulse produced with theoretical predictions.
- d) Determine the best algorithm for obtaining a large dynamic range.
- e) Achieve and maintain $4x6~\mu m$ and larger foci with low jitter and compute target interaction parameters.
- f) Measure parameters of the laser produced plasma, test laser operation and install optical diagnostics.
- g) Measure and verify angular distribution of plume flux.
- h) Select best target materials.
- i) Assess feasibility of the LPT microthruster.

During Phase I, we completed all elements of our statement of work using facilities and personnel at UNM/New Mexico Engineering Research Institute.

3. Technical Accomplishments

3.1 Major achievements correlated to work statement objectives [in brackets]

- [a] We easily measured minimum impulse bits (MIB) equal to one billionth of a newton-second (1E-4 dyne-s) with 10% accuracy, and 1E-5 dyne-s with 50% accuracy [Annex I]. We demonstrated a dynamic range from 0.4 to 16,000 MIB's from a single LPT engine due to a single laser pulse.
- [b] Although the pulser provided with the laser by SDLI is not configured to make pulses longer than 300 ms, we showed that we could implicitly achieve 5 decades in dynamic range of force in one second with a single LPT just by comparing the above response of 16,000 bits per pulse at a 3.3Hz repetition rate to the minimum output of 0.4 bits/pulse at 1Hz giving a dynamic range of 120,000.
- [e] We repeatedly measured laser-ablation impulse produced by a single high-brightness laser diode with 1 watt peak power focused to a 5-µm (0.0002 inch) spot.
- \bullet We measured momentum coupling coefficients C_m up to 25 dyn-s/J. This is among the largest values ever reported in the ablation literature for simple homogeneous materials.
- We saw specific impulse of the laser-produced thruster jet up to 1800 seconds. Widely used competing technologies give 50 seconds (resistojets) and 200-300 seconds (chemical rockets).
- Sixteen materials were studied in 48 data runs producing over 400 impulse data points.
- The laser diode fired thousands of shots without any deterioration in performance.

- We built two torsion balances, one 5 times more sensitive than the other, to do the impulse measurements.
- We noticed no degradation of the target illumination optics due to target debris.
- Results obtained agree well with expectations and theory.

We believe that each of the above accomplishments are first-time achievements, not reported previously in the literature of laser interaction with surfaces.

3.2 Negative results

- [f, g] Using a sensitive plasma detector which we built that was capable of detecting $Q_{min} = 2.4 nC$ (1.5E10 electron charges) and subtending 1 sterradian 1 cm from the target, we failed to detect any plasma signal. This result is consistent with an ionization fraction $\eta_i < 1.4E-6$ in plume. Analysis indicates we were just below plasma threshold with maximum target intensity of 310 kW/cm² delivered to a 5 μ m spot [see Annex V].
- We could not produce impulse on targets with low surface absorptivity and/or high thermal conductivity (e.g., aluminum, fiberglass, cellulose nitrate, kapton, pressed graphite, black anodized aluminum see Annex II) using a 1-watt laser. [See Annex V for discussion]

3.3 Other completed work statement objectives

The remaining objectives not listed above are discussed in the following places in this report:

- [c] Annex IV
- [d] §3.4 of this report, immediately following.
- [h] Annex II
- [i] §3.6 of this report.

3.4 Target illumination algorithm [objective d]

[See the discussion surrounding Figures 11–15 in §3.7.2 following] We found that two target illumination spot sizes, $d_{s1} = 5.2 \mu m$ and $d_{s2} = 200 \mu m$ fullwidth at half-maximum (FWHM) were adequate for all purposes we explored. The available range was set on the low end by minimum possible with the experimental setup.

The small spot size d_{s1} was important for getting coupling at all with pulses shorter than about $\tau=5$ ms [compare Figures 12 and 13 following]. The large spot size d_{s2} was useful, though not crucial, for getting the best coupling coefficient for pulses up to $\tau=300$ ms, the longest duration possible with the SDLI laser pulser provided with the laser. Spots larger than d_{s2} were not useful because no further benefit was achieved, but coupling begins to degrade due to inadequate fluence above this value.

The reason for this is that, after the target is burned through, no more impulse is generated. For 200- μ m diameter illumination spot size our typical 175- μ m-thick targets were burned through after pulse duration exceeded 50ms, and burnthrough was not severe until τ =150ms. On the other hand, for 5- μ m spots, burnthrough started at 10ms, decreasing coupling efficiency above that pulse duration, consistent with the trend of C_m vs. pulsewidth in Figure 12 (blue triangles).

Since all successful targets had about the same thermal diffusivity, the algorithm we developed depends only on pulse duration τ as follows:

IF $100\mu s < \tau < 50ms$	THEN	d_{s1}
IF $\tau >= 50 \text{ms}$	THEN	d_{s2}

Because the radial spacial profile of the focused laser pulse is not a "square hat" but a radial exponential [see Figure 9], it is only important to achieve very small spot size when making impulses of a few bits with short (e.g., 100µs) pulses. This is made visually clear in Figure 11.

3.5 Impulse gage

Our impulse gage is easily capable of measuring one MIB [Figure 2 & Annex I]. It can even measure light pressure (far smaller than ablation pressure). Annex I describes the gage, the gage setup, its theory of operation and its calibration.

3.6. Feasibility of the LPT Microthruster [objective i]

Figure 4 shows our concept for a commercial LPT microthruster. We strongly believe this device has commercial potential. We have demonstrated the advantages that we set out to demonstrate, which are summarized in §1.1. There are no deficits of which we are aware.

One thousand seconds is NOT a fundamental limit for this technology, but is due to the limitations of 1W peak laser power and $5\mu m$ minimum spot size. Specific impulse is determined by ablation temperature, which depends on the laser intensity (W/cm²) we are able to deliver to the target. Values as large as 7000 seconds have been measured by the PI in other laser produced plasmas [Phipps *et al.* 1994].

Figure 4 is an outline drawing of a possible commercial thruster. In the Figure, the target transfer mechanism is visualized as counter-rotating disks to eliminate net torque to the spacecraft. Note

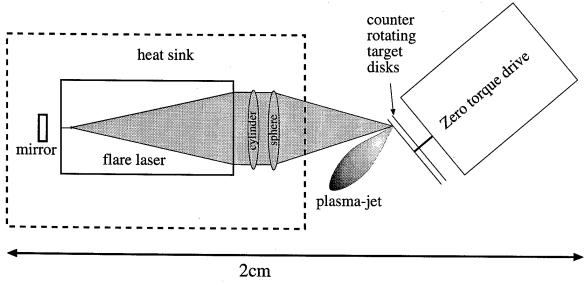


Figure 4: Conceptual Advanced Application Thruster

that linear velocity need not be greater than <u>0.2 mm/s</u> for continuous operation. Technology for focus and alignment need not be as precise as that customarily used in cheap, modern entertainment CD drives.

Developments required on the way to a prototype engine include (but are not limited to):

- a) A target transport mechanism to advance the target material across the laser focus and permit continuous repetitive operation for the life of the on-board ablator
- b) A passive thermal pathway design appropriate for dissipating laser-generated heat to space.

3.6.1 Commercial Potential of the µLPT

Case A: µLPT for microsatellite orientation

Basis: Sales price: \$50k per unit in quantities of 10 - 20

Time Period	Market Potential (units)	<u>Dollar volume</u>
2000 – 2001	6 spacecraft x 6 thrusters = 36	\$2 million
2002 – 2005	10 spacecraft x 6 thrusters = 60	\$3 million
2006 – 2010	100 spacecraft x 6 thrusters = 600	\$30 million

Case B: LPT for microsatellite orbit raising and stationkeeping

Basis: Sales price:

\$250k per unit in quantities of 10 - 20

Time Period	Market Potential (units)	<u>Dollar volume</u>
2000 – 2001	6 spacecraft x 1 thruster = 6	\$1.5 million
2002 – 2005	10 spacecraft x 1 thruster = 10	\$2.5 million
2006 – 2010	100 spacecraft x 1 thruster = 100	\$25 million

We estimate total market at \$64M for just these applications over 10 years. Leverage for funding this project is greater than 100:1.

3.6.2 Potential Customers

Teledesic Corp., Hughes, Motorola (for enhancement of the Iridium satellite system), Caltech Jet Propulsion Laboratory, NASA/Godard Spaceflight Center, US Air Force Research Laboratory Space Vehicles Directorate (Kirtland AFB).

3.6.3 Commercialization Plan

Photonic Associates is highly interested in commercializing LPT's for micro- and nanosatellites. This is a novel invention, and a key stepping-stone to development of LPT's for a broad range of applications. To accomplish commercialization of μ LPT's, PA will undertake the following steps:

- Develop a useful, tested prototype LPT during our proposed Phase II STTR project.
- File patent applications for proprietary aspects of our invention. This step is <u>currently in process</u>, at the stage of prior art search, in partnership with the University of New Mexico.
- Team with a partner who has strong manufacturing capabilities and good access to capital.
- Develop a business plan. The plan may include investment in high brightness glass fiber development, to reduce cost, increase performance, and tailor performance to requirements.
- Obtain early phase venture capital to back this plan.
- Develop an initial line of miniature thruster products which meet the market in §6.1.
- Market the products to entities identified in §6.2
- Make further plans for LPT's based on experience with the marketing effort.
- Develop an expanded business plan for building and marketing macro LPT's and related systems, based on lessons learned in earlier phases.
- Go for second phase venture capital.

3.7 Experimental Setup

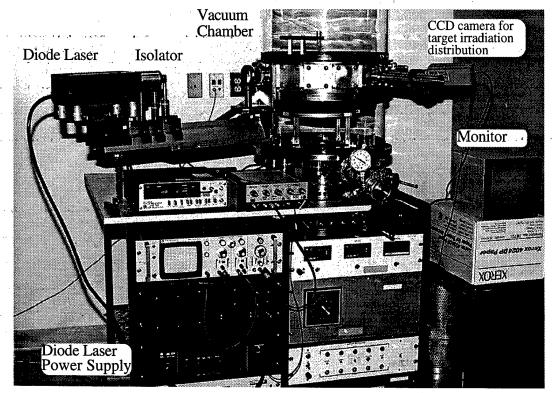


Figure 5: Target irradiation setup

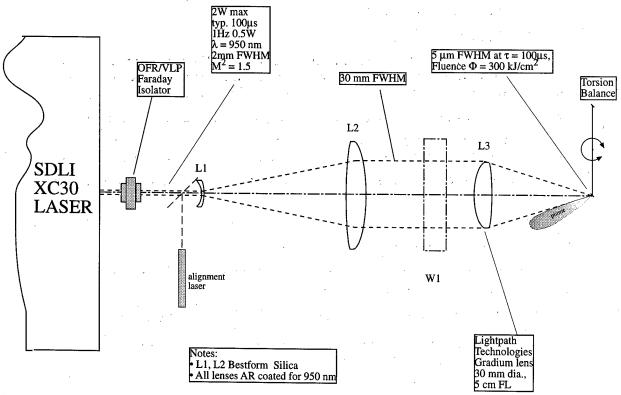


Figure 6: Optical schematic drawing (top view)

Figure 5 shows the target test setup. The Spectra-Diode Labs XC-30 flare-type high-brightness laser is external to the chamber. The test beam is introduced to the chamber as indicated in Figure 6, via a 10X beam expansion telescope (L1-L2) and then focused to a 5- μ m diameter spot by an axial gradient lens which behaves like an asphere.

Figure 7 shows the optical layout in and around the vacuum chamber

3.8 Major results obtained

3.8.1 Focal Spot Size [work stmt objective e]

Figure 8 shows a typical beam intensity trace, and Figure 9 shows the statistical average of several measurements. We could repeatedly

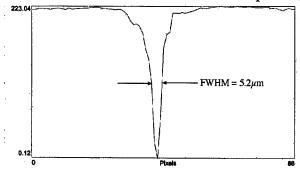


Figure 8: Beam diameter on target

Laser Beam Radial Intensity Profile on Target 1/7/99

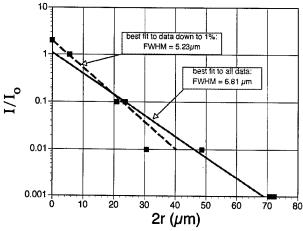


Figure 9: Data down to 1% of peak is consistent with 5.2 µm diameter

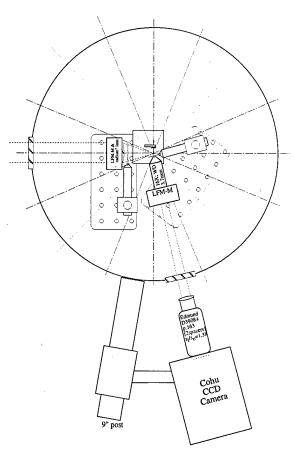


Figure 7: In-chamber optical arrangement (top view)

obtain focal spot diameters of 5.2µm, which meets the requirements of our work statement. Jitter was less than 25%, which was the minimum measurable diameter in a single measurement, since such a spot size illuminated only 4 pixels on our CCD camera using the highest magnification microscope objective that would not interfere with the ablation laser beam.

The position of external lens L3 is a coarse adjustment that translates to a very fine adjustment of the axial position of the beam focus relative to the target, with a leverage of 60:1 [see figure 10]. Using this feature, we could carefully adjust the focal spot size after the test chamber was pumped down. This capability was especially important with the 5.2µm spots, but could also produce defocused spots of size 100 and 200µm, which we used to see how coupling varied with fluence. These larger spot sizes on target were also important for obtaining the best possible coupling at long (>50ms) pulse durations (see Annex IV).

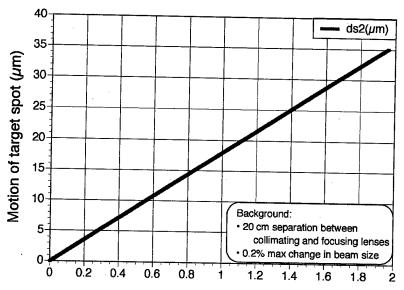


Figure 10. Method for precision control of focal spot position

2" collimating lens z motion (mm)

Laser parameters for peak momentum coupling in vacuum(46 experiments, UV-IR, all materials plus LPT)

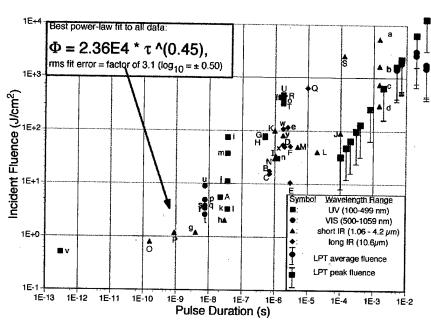


Figure 11: Optimum coupling fluence agrees well with predictions

with various targets are shown in Figures 14-17.

3.8.2 Laser Ablation Impulse Measurements

Annex II is a summary listing of all targets tested, with data obtained. Annex III discusses the physics of laser momentum coupling during ablation of a solid surface - in particular how coupling data experiments reported in the ablation literature give a definite trend of peak coupling fluence vs. pulsewidth. In writing the Phase I proposal, we used this trend to predict how our LPT would operate.

Figure 11 shows how typical data we took during Phase I agrees with this prediction.

It was important to calculate, for

each spot size and torsion pendulum mass, how much the target would move during the laser pulse which could be as long as 0.3 seconds. Annex IV shows how average fluence (shown in green in Figure 11) was calculated.

Figure 12 shows some typical target burn spots taken in vacuum, ranging in size from $20\mu m$ to $750\mu m$ in diameter. These were taken with (Upper) $5\mu m$ focal spot size and (Lower) $200\mu m$ spot size on PVC film.

Our best LPT performance results

Figures 14 and 15 compare the performance of black polyvinylchloride film at 5- μ m laser spot size with what we obtained with 200- μ m spotsize.

Note that I_{sp} is lower but C_m stays higher for longer pulses with the larger spotsize. Figure 12, taken with the target that produced the Figure 14 and 15 data, shows why. For 200- μ m diameter

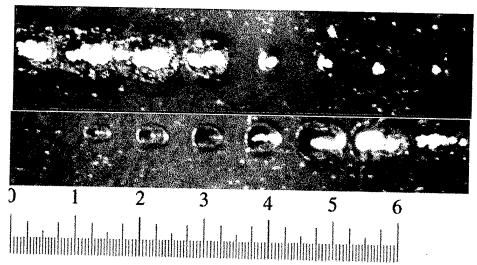


Figure 12: Photomicrographs of target burn spots ranging from $20\mu m$ to $750 \mu m$ in diameter, taken with $5\mu m$ (upper) and $200\mu m$ (lower) laser spot size. Graticule lines are spaced $50\mu m$. Film was 175 μm thick.

illumination spot size, the $175-\mu m$ thick film was burned through only after pulse duration exceeded 50ms and burnthrough was not severe until τ =150ms. On the other hand, for 5μm spots, burnthrough started at 10ms, decreasing coupling efficiency above that pulse with

duration, consistent the trend of C_m vs. pulsewidth in

Table 2: Results for Best Targets [0.4W incident peak power]

Material	$\mathbf{Max} \\ \mathbf{I_{sp}}(\mathbf{s})$	Max C _m (dyn-s/J)	Min Impulse (bits)	Max Impulse (bits)
Black PVC film	750	24	3	16,000
Black ink on thick paper	2,000	17	1	9,000
Black laser print on paper	150	10	2	5,000

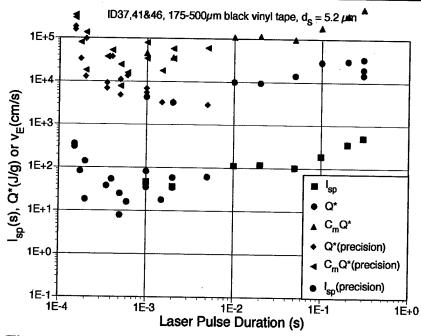
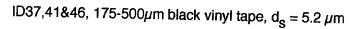


Figure 13: Q* values are determined by microscopic examination of the target

Figure 14 (blue triangles).

Figure 16 shows the performance of black printer's ink on 350-um thick paper. Specific impulse was notable with this target, reaching values as large as I_{sp} 2,000 s. Coupling remained high over much of the pulsewidth range. This data is interesting because of the tremendous range of impulse demonstrated from a single target.

If it is desired to have maximum coupling coefficient combined with very small MIB, Figure 17 shows the behavior of a target constructed from 10- μm mylar foil with a 1-2- μm black ink coating.



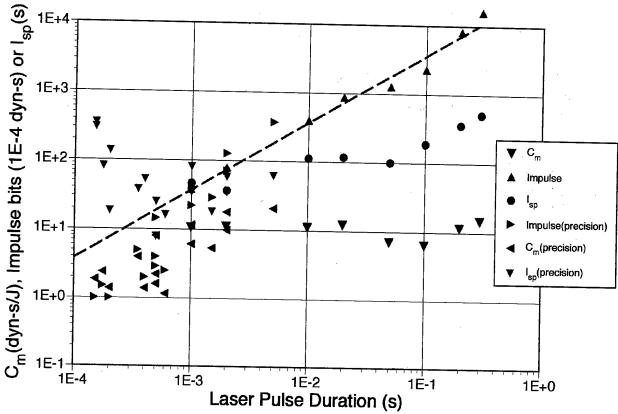


Figure 14: Target: black PVC film 175 μ m thick. Laser spot size 5μ m.

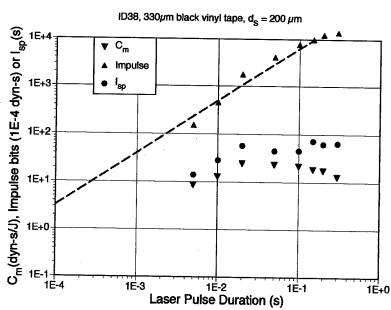


Figure 15: Same as Figure 14, but $d_s = 200 \mu m$.

Figure 14 is our most thorough set of data for our best target material. It is composed of data from three sources: the heavy and light torsion balances, and the light balance with maximum range (340 cm) for the readout beam ("precision" data). Because this beam has to pass through a 2-inch target port window, "precision" data can be obtained only for a very limited range of deflections, so it is a special setup rarely used.

Note how C_m decreases, while Q* increases for the short pulses. This makes sense because of the increasing dominance of thermal conduction as an energy sink for very small ablation pits.

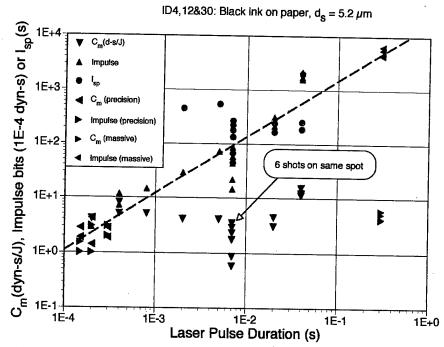


Figure 16: Black printer's ink on 350-\mu m-thick paper. Specific impulse reaches 2,000s. Coupling coefficient up to 17 dyne-s/J is seen.

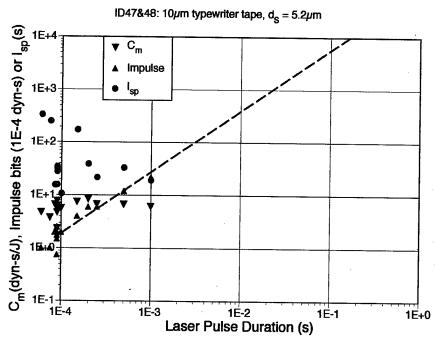


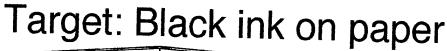
Figure 17: Black ink on 10- μ m mylar foil. Excellent coupling coefficient together with acceptable $I_{s\,p}$ are maintained down to $50\mu s$ pulsewidth and 0.75 bits.

3.8.3 Q* and Isp

Figure 13 shows the Q* data which is the basis for the I_{sp} values plotted in Figure 14. Annex III [Eqn. AIII.16] explains the connection between Q* and I_{sp} . Because the quantities mass ablated are so small (often of order 10 nanograms), the only reasonable way to determine Q* is by careful microscopic measurement of the volume of each ablation pit. This was a bit tedious, but gave good results. We did this for each data point in the test series, and used the product C_mQ^* to calculate I_{sp} .

3.8.4 "Gold Bar" Validation

Because we have so much coupling data, it is possible for the first time to assemble 3-dimensional shape which shows how well experimental data support the dependence of peak coupling on fluence and pulsewidth predicted by Eqn. AIII.2 Annex III]. Figure 18 shows such a plot, assembled from the data for one particular target material. The height of the 3-dimensional shape in the figure is coupling coefficient C_{m} and the horizontal coordinates are fluence and pulsewidth. The gold bar plotted on the baseplane is the same one shown in Figure AIII.1 and Figure showing that agreement with the purely theoretical Eqn. AIII.2 prediction is quite good.



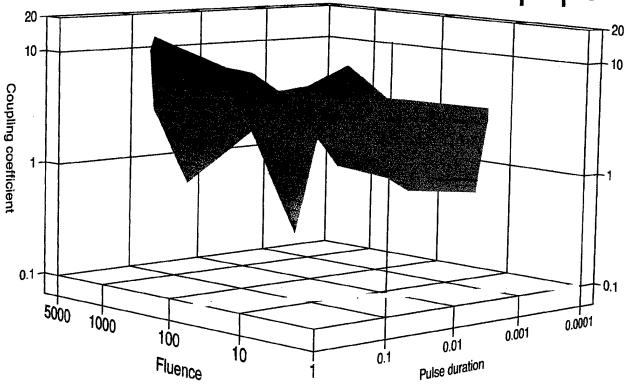


Figure 18: Three-dimensional data plot (not a simulation) of C_m vs. Φ and τ . The gold bar on the floor of this figure is discussed in Annex III.

3.8.5 Precision Material Removal

The holes made in target materials for low energy ablation shots were very precise. Figures 19a and 19b are, respectively, a blowup of the smallest spot in Figure 12, and a photomicrograph of the ablation feature produced on aluminized mylar. There may be applications for precise hole drilling based on this work.

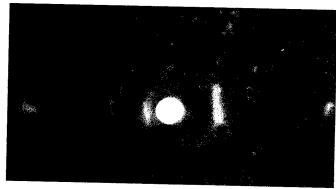


Figure 19a: Magnified view of smallest spot in Figure 12. Feature diameter is $20\mu m \pm 10\%$. Pulse duration 5ms.

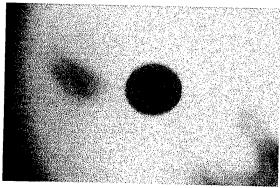


Figure 19b: $125\mu m$ kapton with aluminum flashcoat. Feature diameter is $180\mu m \pm 5\%$. Laser spot size $\tau = 200 ms$, $\langle \Phi \rangle = 280 J/cm^2$.

As a very interesting aside for our program, <u>thrust reversal</u> i.e. forward rather than backward thrust, was seen with aluminized kapton illuminated from the kapton side. This should be explored further during Phase II.

4. Personnel. Publications, Inventions

Personnel directly involved in the theoretical and experimental work for this project were:

Dr. Claude Phipps Photonic Associates, Santa Fe, NM (PI for prime contractor)

Dr. James Luke University of New Mexico, New Mexico Engineering Research Institute,

Albuquerque, NM (PI for subcontractor)

Publications: None at this writing

Inventions: None. The University of New Mexico is conducting a prior art search in preparation for possibly filing a patent application on behalf of Photonic Associates and UNM, joint applicants. However, a decision on whether or not to file has not been made at this date.

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Annex I: Phase I Torsion Microbalance - Theory and Calibration

We constructed one of the most sensitive pendula ever made [Figure AI.1]. The Figure shows the factors involved in the torsion pendulum's rotational response to laser-produced impulse. We are measuring material ablation pressure here, not light pressure. However, our pendulum is sufficiently sensitive to detect light pressure.

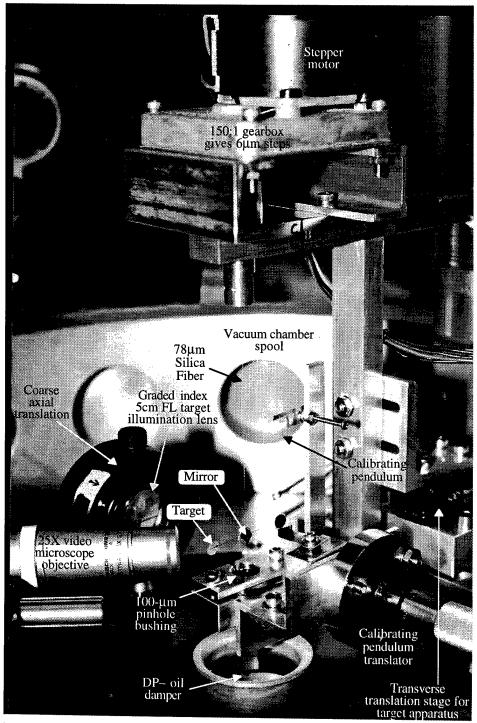


Figure AI.1: The torsion pendulum, under calibration

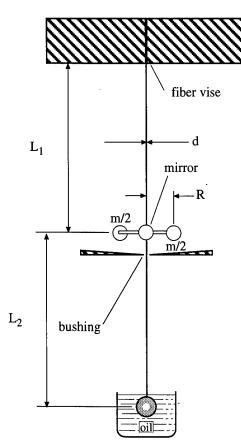


Figure AI.2: Parameters used in analysis

Torque defines the constant k:

$$M = F R = k \theta$$
 [AI.1]

$$k = \frac{GJ}{L}$$
, where [AI.2]

$$J = \frac{\pi d^4}{32} \qquad . \qquad [AI.3]$$

Equating kinetic and stored energy,
$$W = \frac{k \theta_o^2}{2} = \frac{p^2}{2 \text{ m}} = \frac{I \omega_o^2 \theta_o^2}{2} \quad \text{[AI.4]}$$

gives the resonant frequency,

$$\omega_{\circ} = \sqrt{\frac{k}{I}}$$
 . [AI.5]

From [AI.4], the impulse response of the pendulum is:

$$\frac{p}{\theta_o} = \sqrt{k m} = \sqrt{\frac{G J m}{L}} = \sqrt{\frac{\pi G m}{32 L}} d^2 \qquad \text{, and} \qquad [AI.6]$$

$$\frac{F}{\theta_0} = \frac{GJ}{LR}$$
 [AI.7]

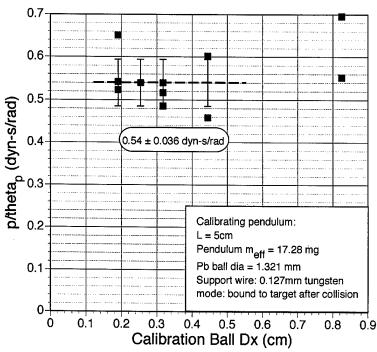
Table AI.1: Glossary

	_	
Sym -bol	<u>Definition</u>	Value or equivalence
$C_{\rm m}$	Coupling coefficient	dyn-s/J
d	Fiber diameter	78±0.5 E-4 cm
Е	Fiber Young's modulus	7.08E11 dyn/cm ²
f_0	Resonant frequency	Hz
F	Force	dyn
g	Acceleration of gravity	cm/s ²
G	Torsion modulus	3.00E11 dyn/cm ²
Ι	Rotating mass moment	(mR^2) gm-cm ²
J	Fiber polar moment	cm ⁴
k	Torsional spring constant	GJ/L
L	Effective fiber length	$[1/L_1+1/L_2]^{-1}$ cm
m	Effective mass at radius R	gm
M	Torque	dyn-cm
n/m	not measured	·
р	Impulse	dyn-s
θ	Rotation angle	rad
θ_{b}	Deflection angle of probe	rad
$\theta_{\rm o}$	Rotation amplitude	rad
R	Impulse moment arm	2 cm
σ	Fiber tensile strength	5.39E8 dyn/cm ²
Т	Oscillation period	$(2\pi/\omega_{\rm o})$ s
W	Rotation kinetic energy	erg
W_{L}	Incident laser energy	J
$\omega_{\rm o}$	Resonant frequency	2πf _o rad/s
Z	Range to video recorder	cm

is the force response.

These relationships suggest four distinct ways of determining the precise value of the product GJ by either calibration or direct calculation:

From Eq. [AI.3] by observing the resonant frequency of i =1,2 (light, heavy) pendulum and



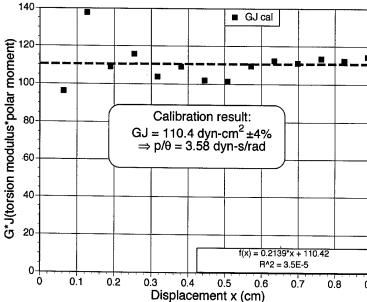


Figure AI.3: Impact calibration (upper) was much less accurate than static force calibration (lower figure)

calculating the effective rotating mass:

$$(GJ)_{1i} = L_i m_i R^2 \omega_{0i}^2$$
 [AI.8a]

or, by direct calculation based on tabulated material constants for our 78µm diameter fused silica fiber:

$$(GJ)_2 = \frac{\pi d^4 G}{32} = 109.0$$
 [AI.8b]

or, by applying a known force from a standard pendulum and observing the deflection θ :

$$(GJ)_{3i} = \frac{F_i L_i R}{\theta_i}$$
 [AI.8c]

or by applying a known <u>impulse</u> via a collision from a standard pendulum and observing the deflection amplitude:

$$(GJ)_{4i} = \frac{p^2 L_i}{m_i \theta_{ai}^2}$$
 [AI.8d]

Of these, method 3 proved by far the most successful in generating a precise result. With method 4, finding the correct coefficient of restitution for zero recoil of the test mass was very difficult, and accurately measuring the recoil was difficult. In contrast, with method 3, the measured variables were simple and static, giving a measurement accuracy better than 5% [Figure AI.3].

Given an accurate value for k, what is ultimately desired, of course, is the momentum coupling coefficient C_m [which is universally tabulated in the literature in mixed units (dyn-s/J)]:

$$C_m = (p/\theta_o)(\theta_o/W_L)$$
 . [AI.9]

The angles θ are evaluated by reflecting a probe laser off a

Figure AI.4: Static force calibration setup

micromirror mounted to the center of the torsion mechanism [Figures AI.1, 2]. The force calibration is illustrated in Figure AI.4. It is necessary to take account of the fact that both pendula move when the test pendulum is advanced a distance x via a micrometer stage. We have

$$\mathbf{x}_2 = \mathbf{x} - \mathbf{x}_1 \tag{AI.9}$$

$$F_2 = m_{eff} g \tan \psi$$
 and [AI.9]

$$GJ = \frac{2 F_2 R L}{\theta_b}$$
 [AI.10]

from Eq. [AI.8c] with $\theta_i = \theta_b/2$. This simple method resulted in the precise data shown in Fig. AI.3 (lower). We note [Table AI.1] that the value for GJ agrees very well (within 1%) with the calculated value (GJ)₂.

The more customary alternative of calibration via impact of a test pendulum was relatively inaccurate. We could not achieve zero coefficient of restitution in the test mass, and resonances in both structures made it difficult to accurately determine the test mass rebound. We then settled on making the test mass stick to the torsion pendulum - a case easier to analyze - but then, the Q of the

coupled pendulum oscillation was very low, and the correction for damping was consequently inaccurate.

Summary: In practical terms, then, using the best values in Table AI.1, we have:

$$\frac{F}{\theta} = \begin{pmatrix} 13.40 \\ 11.04 \end{pmatrix} dyn / rad$$
 for the $\begin{pmatrix} light \\ heavy \end{pmatrix}$ pendulum, respectively, [AI.11a]

and
$$\frac{p}{\theta} = \begin{pmatrix} 0.681 \\ 3.58 \end{pmatrix} dyn - s / rad$$
 for the $\begin{pmatrix} light \\ heavy \end{pmatrix}$ pendulum, [AI.11b]

as indicated in the Table. The items in the last column of Table AI.1 differ because the effective lengths L_i of the two pendula differ.

Table AI.1: Calibration Results for the Torsion Pendula

Pend.	f _o (Hz)	Mass m(mg)	L ₁ (cm)	L ₂ (cm)	(GJ) ₁	(GJ) ₂	(GJ) ₃ (GJ) ₄	Final p/θ (dyn-s/rad)	Final F/θ (dyn/rad)
Light	1.73	17.28	10	7	33.64	109.0	n/m 69.53	0.681±4%	13.40
Heavy	0.333	579.6	10	10	50.75	109.0	110.4 n/m	3.58±4%	11.04

Recording Setup

Figure AI.5 shows the recording setup.

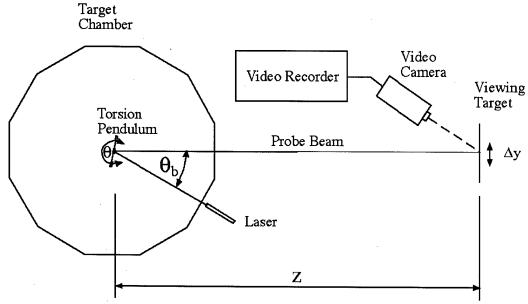


Figure AI.5. The Impulse Recording Setup

Sensitivity

Keeping in mind that reflection of the probe \underline{beam} θ_b from the microbalance mirror doubles the rotation angle of the $\underline{balance}$ θ :

$$\theta_b = 2\theta$$
 [AI.12]

the <u>sensitivity</u> of the final device simply depends on the minimum deflection amplitude Δy we can read and the range z to the target on which the video system records this reading:

$$\theta_{\rm b \ min} = \Delta y/z$$
 . [AI.13]

We used two ranges, which are listed, together with corresponding sensitivity at $\pm 50\%$ in Table AI.2.

Table AI.2: Pendulum Sensitivity at $\pm 50\%$ Accuracy [$\Delta y_{min} = 0.1$ mm]

Pend.	p/θ (dyn- s/rad)	$\Delta\theta_{\min}$ @ z=340 cm (μ rad)	$\Delta\theta_{min}$ @ z=23.5 cm (μ rad)	Δp_{min} : @ $z = 340 \text{ cm}$ (dyne-s)	Δp_{min} : @ z = 23.5 cm (dyne-s)
Light	0.681	14.7	213	1.00E-5	1.45E-4
Heavy	3.58	14.7	213	5.26E-5	7.63E-4

Maximum response as presently configured occurs with the heavy pendulum, z=23.5 cm and $\Delta y_{max} = 25$ cm, giving $\Delta p_{max} = 1.90$ dyne-s.

Measuring Light Pressure

The effective coupling coefficient for reflection of light (with no ablation) is

 $C_m = 2/c$ in consistent units or

= 6.7E-4 dyne-s/J in customary units

[AI.14]

[Phipps, et al. 1988]. If we apply our laser to a reflecting target on the light pendulum in its maximum sensitivity configuration (z=340 cm) without a focusing lens, at intensities of order 0.5 W/cm², any deflection seen will be due to light pressure, not ablation.

We did this on the final day of our experimental program and were able to see light pressure quite well.

The target was aluminized mylar, 1cm x 5mm. Maximum cw intensity on the target was 700mW/cm² (about 7 suns) and maximum pulse fluence was 300mJ/cm². With a maximum pulse duration of 150ms in the test, we obtained deflection (in the correct direction) of 15 times the minimum measurable response. We were still able to see light pressure deflection down to 10ms.

Chamber pressure was 1.6E-4 torr.

Photonic Associates F49620-98-C-0038 App 2 Page 23 of 54 version 7/2/99 Annex II: Target Matrix [objective h]

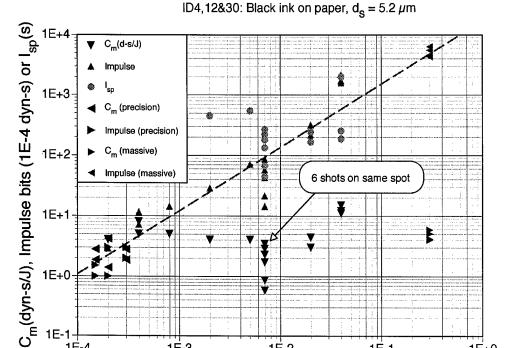
Table AII.1. Test Summary

Test ds t Hay Min Max Min Max Min Max Cm Q* Cm Q* Is Is Min Max Min 4,12 Black printer's 5 330 X 0.1 40 65 1.70E+3 15 1.6E5 2000 1 1740 6.0 Black printer's 5 350 X 100 300 64 3.12E3 5.9 6400 6 Black printer's 100 350 X 100 300 64 3.12E3 5.9 6400 1.2 Black printer's 100 350 X 10 30 4.30E+1 2.8 1.0 3.0 4.30E+1 2.8 1.0 3.0 4.30E+1 3.0 1.0 3.0 1.1 3.0 1.0 3.0 4.30E+1 2.3E+1 3.0 1.0<		·			Pen	end.	Pulse width	lse Ith	Fluc	Fluence	Maxin	Maximum values	lues	Imp	Impulse ((bits)
Black printer's ink-paper 5 350 X 100 300 64 3.12E3 5.9 6400 Black printer's ink-paper 350 X 100 300 64 3.12E3 5.9 6400 Black printer's ink-paper 100 350 X 0.2 50 9.1 4.30E+1 2.8 7 300 Black printer's ink-paper 200 350 X 10 300 11 3.40E+2 1.8 3.3E4 180 114 2170 Black printer's ink-paper 200 350 X 10 300 11 3.4EE+2 8.8 3.3E4 180 114 2170 Kerographic ink-paper 200 30 32 4.64E+3 8.1 9.7E4 135 2 2320 Merographic ink-paper 30 10 30 3.2 4.64E+3 8.1 9.7E4 130 Macepaper 30 <th>Test Nos</th> <th></th> <th>d_s</th> <th>t (μm)</th> <th>Lt</th> <th>Hvy</th> <th></th> <th>Max (ms)</th> <th>Min J/cm²</th> <th>Max I/cm²</th> <th>C_{m}</th> <th>Q*</th> <th>Ls p (S)</th> <th>Min</th> <th></th> <th>Log Ratio 1)</th>	Test Nos		d _s	t (μm)	Lt	Hvy		Max (ms)	Min J/cm ²	Max I/cm ²	C_{m}	Q*	Ls p (S)	Min		Log Ratio 1)
Black printer's 5 350 X 100 300 64 3.12E3 5.9 6400 liktyaper Black printer's 100 350 X 0.2 50 9.1 4.30E+1 1.8 7 300 liktyaper 200 350 X 10 300 11 3.4E+2 8.8 3.3E4 180 114 9370 Black printer's 200 350 X 10 300 11 3.6E+2 8.8 3.3E4 180 114 9370 Kerographic 5 100 X 5 300 5.7 1.50E+2 9.5 3.3E4 180 114 9370 Kerographic 5 100 X 5 300 5.7 1.50E+2 9.5 3.3E4 180 114 9370 Kerographic 5 105 X 5 300 5.7 1.50E+3 1.6E+3 1.6E+	4,12	Black printer's ink:paper	5	350	×		0.1	40	65	1.70E+3	15	1.6E5	2000		1740	
Black printer's ink: paper 100 350 X 0.8 60 3.7 3.40E+2 10 2.3E5 830 14 2170 Black printer's ink: paper 200 350 X 10.2 50 9.1 4.30E+1 2.8 3.3E4 180 114 9370 Black printer's paper 200 350 X 10 300 11 3.64E+2 8.8 3.3E4 180 114 9370 Merographic 5 100 X 5 300 5.7 1.50E+2 9.5 3.3E4 180 114 9370 Kerographic 200 100 X 5 300 5.7 1.50E+2 9.5 3.3E4 130 76 5260 Merographic 200 100 X 5 300 5.7 1.50E+2 9.5 3.3E4 30 76 5260 Merographic 200 10.5 X 1 300 5.7 1.50E+2	30	Black printer's ink:paper	5	350		×	100	300	49	3.12E3	5.9	- [6400	
Black printer's 200 350 X 0.2 50 9.1 4.30E+1 2.8 7 300 ink:paper Black printer's 200 350 X 10 300 11 3.64E+2 8.8 3.3E4 180 114 9370 Merographic 5 100 X 5 30 5.7 1.50E+2 9.5 3.3E4 135 2 2320 black:paper X 0.1 80 3.7 1.50E+2 9.5 3.3E4 230 76 5200 black:paper X 0.1 8 3.5E+3 2.1 1.6E5 3.0 5.7 1.50E+2 9.5 3.3E4 230 76 5200 black:paper X 1.75 X 1 300 5.7 1.50E+2 9.5 3.3E4 230 7 1.54E4 Thin PVC film 5 1.75 X 1 30 5.7 8.90E+1 2	9	Black printer's ink:paper	100	350	×		8.0	09	3.7	3.40E+2	10	2.3E5	830	14	2170	
Black printer's ink: raylar 200 350 X 10 300 11 3.64E+2 8.8 3.3E4 180 114 9370 Merographic black; paper 5 100 X 0.1 80 32 4.64E+3 8.1 9.7E4 135 2 2320 Merographic black; paper 200 100 X 5 300 5.7 1.50E+2 9.5 3.3E4 230 76 5260 Thin PVC film 5 175 X 1 300 3.55E+3 21 1.6E5 350 1 370 Thin PVC film 5 175 X 1 300 3.5E+3 21 1.6E5 350 1 370 Thin PVC film 5 175 X 1 300 3.5E+3 2 4.4E5 465 12 1840 Thin PVC film 5 175 X 2 300 5.7 8.90E+1 24 4930 72 1840 </td <td>17</td> <td>Black printer's ink:paper</td> <td>200</td> <td>350</td> <td>×</td> <td></td> <td>0.2</td> <td>50</td> <td>9.1</td> <td>4.30E+1</td> <td>2.8</td> <td>-</td> <td>1</td> <td>7</td> <td>300</td> <td></td>	17	Black printer's ink:paper	200	350	×		0.2	50	9.1	4.30E+1	2.8	-	1	7	300	
Kerographic 5 100 X 0.1 80 32 4.64E+3 8.1 9.7E4 135 2 2320 black:paper Xerographic 200 100 X 5 300 5.7 1.50E+2 9.5 3.3E4 230 76 5260 Plack:paper 7 175 X 0.1 5 850 3.5E+3 21 1.6E5 350 1 370 Thin PVC film 5 175 X 1 300 5.7 8.90E+1 24 4930 72 1840 Thin PVC film 5 500 X 2 300 5.7 8.90E+1 24 4930 72 1840 Thin PVC film 5 500 X 0.1 20 80 2.20E+3 20 4.4E5 465 12 1840 Thick PVC film 5 5.50 X 2 30 6.4 2.9 1930 Phe	21,22		200	350		×	10	300	11	3.64E+2	8.8	3.3E4	180	114	9370	3.97
Xerographic 200 100 X 5 300 5.7 1.50E+2 9.5 3.3E4 230 76 5260 Plack:paper Thin PVC film 5 175 X 0.1 5 850 3.55E+3 21 1.6E5 350 1 370 Thin PVC film 5 175 X 1 300 3.5E+3 12 3.4E4 505 38 1.6E4 Thin PVC film 5 175 X 2 300 5.7 8.90E+1 24 4930 72 1840 Thick PVC film 5 500 X 0.1 20 80 2.20E+3 20 4.4E5 465 12 1840 Phenolic resin 5 250 X 0.8 100 640 5.7 29 1930 Phenolic resin 5 250 X 10 300 11 1.53E+2 6.4 8840 43 12	9,16	Xerographic black:paper	5	100	×		0.1	80	32	4.64E+3	8.1	9.7E4	135	2	2320	
Thin PVC film 5 175 X 0.1 5 850 3.55E+3 21 1.6E5 350 1 370 Thin PVC film 5 175 X 1 300 320 8.55E+3 12 3.4E4 505 38 1.6E4 Thin PVC film 5 175 X 2 300 5.7 8.90E+1 24 4930 72 1840 Thick PVC film 5 500 X 0.1 20 80 2.20E+3 20 4.4E5 465 12 1840 Phenolic resin 5 250 X 0.8 100 640 5.7 29 1930 Phenolic resin 5 250 X 10 300 640 5.7 38 5640 Phenolic resin 5 50 X 10 300 11 1.53E+2 8.4 7.0E4 33 0.75 22 <t< td=""><td>24</td><td>Xerographic black:paper</td><td>200</td><td>100</td><td></td><td>×</td><td>2</td><td>300</td><td>5.7</td><td>1.50E+2</td><td>9.5</td><td>3.3E4</td><td>230</td><td>9/</td><td>5260</td><td>3.42</td></t<>	24	Xerographic black:paper	200	100		×	2	300	5.7	1.50E+2	9.5	3.3E4	230	9/	5260	3.42
Thin PVC film 5 175 X 1 300 320 8.55E+3 12 3.4E4 505 38 1.6E4 Thin PVC film 200 175 X 2 300 5.7 8.90E+1 24 4930 72 12 1840 Thick PVC film 5 500 X 0.1 20 80 2.20E+3 20 4.4E5 465 12 1840 Phenolic resin 5 250 X 2 300 640 5.7 29 1930 Phenolic resin 5 250 X 2 300 640 5.7 38 5640 Phenolic resin 5 50 X 10 300 11 1.53E+2 6.4 8840 43 12 1840 Black ink: mylar 5 5 X 2 300 2.3 2.30E+2 6.4 2.9E4 72 12 12 <td>41,46</td> <td></td> <td>5</td> <td>175</td> <td>×</td> <td></td> <td>0.1</td> <td>5</td> <td></td> <td>3.55E+3</td> <td>21</td> <td>1.6E5</td> <td>350</td> <td></td> <td>370</td> <td></td>	41,46		5	175	×		0.1	5		3.55E+3	21	1.6E5	350		370	
Thin PVC film 200 175 X 2 300 5.7 8.90E+1 24 4930 72 12 1840 Thick PVC film 5 500 X 0.1 20 80 2.20E+3 20 4.4E5 465 12 1840 Phenolic resin 5 250 X 2 300 640 5.7 29 1930 Phenolic resin 5 250 X 2 300 640 5.7 38 5640 Phenolic resin 200 250 X 10 300 11 1.53E+2 6.4 8840 43 12 1840 Black ink: mylar 5 50 X 2 300 2.3 2.30E+2 6.4 2.9E4 72 12 1840	37	Thin PVC film	5	175		×	_	300	320	8.55E+3	12	3.4E4	505	38	1.6E4	
Thick PVC film 5 500 X 0.1 20 80 2.20E+3 20 4.4E5 465 12 1840 Phenolic resin 5 250 X 2 300 640 5.7 29 1930 Phenolic resin 5 250 X 10 300 11 1.53E+2 6.4 8840 43 12 1840 Black ink: mylar 5 50 X 0.05 1 19 3.13E+2 8.4 7.0E4 330 0.75 22 Black ink: mylar 200 50 X 2 300 2.3 2.30E+2 6.4 2.9E4 72 12 1840	38	Thin PVC film	200	175		×	2	300		8.90E+1	24	4930	72	12	1840	
Phenolic resin 5 250 X 0.8 100 615 5.56E+3 10 29 1930 Phenolic resin 5 250 X 10 300 11 1.53E+2 6.4 8840 43 12 1840 Phenolic resin 200 250 X 10 300 11 1.53E+2 6.4 8840 43 12 1840 Black ink: mylar 5 50 X 2 300 2.3 2.30E+2 6.4 2.9E4 72 12 1840	44	Thick PVC film	5	200	×		0.1	20		2.20E+3	20	4.4E5	465	12	1840	4.20
Phenolic resin 5 250 X 2 300 640 5.7 38 5640 Phenolic resin 200 250 X 10 300 11 1.53E+2 6.4 8840 43 12 1840 Black ink: mylar 5 50 X 2 300 2.3 2.30E+2 6.4 2.9E4 72 12 1840	∞	Phenolic resin	5	250	×		8.0	100		5.56E+3	10		-	29	1930	
Phenolic resin 200 250 X 10 300 11 1.53E+2 6.4 8840 43 12 1840 Black ink: mylar 5 50 X 2 300 2.3 2.30E+2 6.4 2.9E4 72 12 1840	53	Phenolic resin	5	250		×	2	300			5.7		1	38	5640	
Black ink: mylar 50 X 0.05 1 19 3.13E+2 8.4 7.0E4 330 0.75 22 Black ink: mylar 200 50 X 2 300 2.3 2.30E+2 6.4 2.9E4 72 12 1840	31	Phenolic resin	200	250		×	10	300	11	1.53E+2	6.4	8840	43	12	1840	2.67
Black ink: mylar 200 50 X 2 300 2.3 2.30E+2 6.4 2.9E4 72 12 1840	47,48		5	50	×		0.05	-		3.13E+2	8.4	7.0E4	330	0.75	22	
	23	Black ink: mylar	200	50		×	2	300		2.30E+2	6.4	2.9E4	72	12	1840	3.39

				Per	end.	Pulse width	lse Ith	Flu	Fluence	Maxii	Maximum values	lues	dwI	Impulse (bits)	bits)
Test		q	+			Min	Max	Min	Max	٦	*	Len	1	,	1,00
Nos	Target	\Box	(mm)	Lt	Hvy	(ms)	(ms)	J/cm ²	J/cm ²	(d-s/J)		(s)	Min	Max	Ratio 1)
25	Black ink: mylar sandwich	200	100		X	-	300		2.30E+2	1	l	1			
43	Black ink:glass ²⁾	5	06	X		0.1	20	32	1.35E+3	22	2.6E4	311	3.6	556	
42	Black ink:glass	100	06	X		0.1	20	6.0	4.70E+1	16	1.4E4	132	3.6	674	2.27
32	Black thin polyethylene	5	100		×	5	300	1600	6.50E+4	0.21	1.7E4	1.5	15	9/	
34	Black thick polyethylene	5	850		×	50	300	1.4E4	2.00E+4	1.5	2600	3.6	150	1500	2.00
45	Kapton	5	125	×		0.2	200	320	6.50E+3	ł	1	-	1		
13	Photographic film	5	175	X		0.1	09	16	8.54E+3	7.4	1.7E4	16	0.5	72	2.16
18	Audio tape	5	20	×		0.1	08	95	7.90E+3	6.7	1.2E5	300	3.6	145	
19,20	Audio tape	200	20	×	×	∞	300	9.2	3.00E+2	2.6	3.3E4	15	57	380	2.02
26	Graphite sheet	5	380		×	100	300	0099	2.00E+4						
40	Viton	5	300		×	-	300	0908	4.80E+4	10.6	3.3E4	227	12	563	1.69
10	Se black: Al	5	100	×		8.0	08	380	4.05E+4	1			l	1	
11	Black ink:vinyl copolymer	5	25	×		8.0	08	3140	4.05E+4	0.9	-		4	58	0.12
33	Cellulose nitrate	5	0/		X	2	300	950	9.24E+4		-	1			
39	Black anodize: Al	5	200		×	2	300	950	9.24E+4	1	-	1			
36	Fiberglas	5	1500		×	2	300	950	9.24E+4	-	1			1	

Notes:

¹⁾ For the material, independent of the spot size or the balance used to measure impulse 2) Same ink as expt. 23, dissolved and applied to glass cover slide in a thick layer 3) Constant factors: Incident power 360mW, p<1mtorr



Laser Pulse Duration (s)

1E-1

1E+0

1E-3

1E-1 1E-4

Figure AII.1 [ID4,12] Black printer's ink on 350-µm paper substrate, 5µm spot

Same as Figure 16 of main text. The multiple-shot data point shows gracefully the thrust from a single point degrades. Data such as this created the 3dimensional Figure 18 of the maint text.

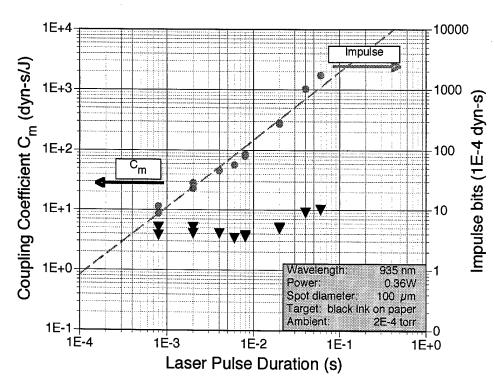


Figure AII.2 [ID6]

Black printer's ink on paper, as Figure AII.1 but 100-µm spot.

No significant difference in coupling is seen.

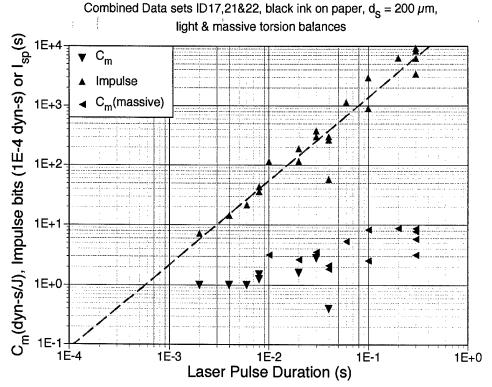


Figure AII.3 [ID17,21&22]

Black printer's ink on paper, same as previous two Figures, but 200µm spot.

Still no significant difference in coupling from the smaller spots.

ID9, Laser print on bond, $d_S = 5.2 \mu m$

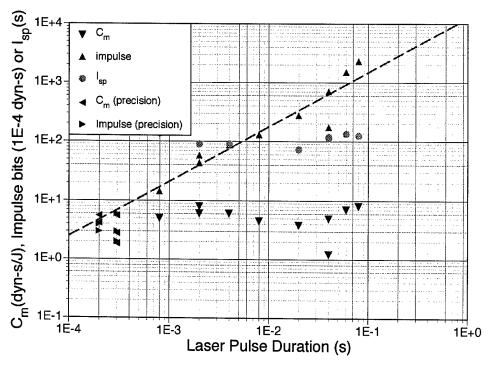


Figure AII.4 [ID9,16]

Laser print on white bond paper, 5µm spot

Laser print on bond paper gave good C_m , but not very exciting I_{sp} .

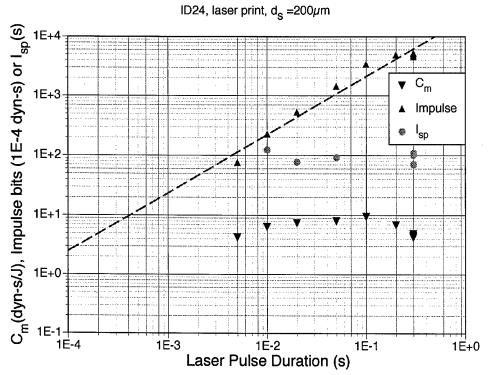
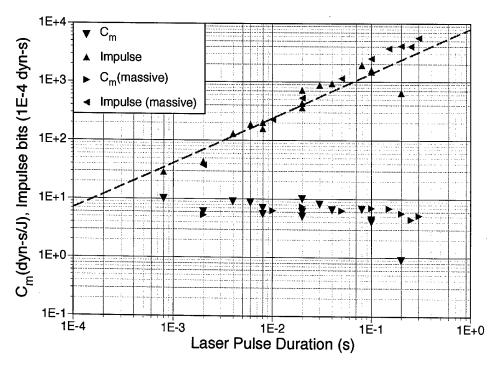


Figure AII.5 [ID24]

Laser print on white bond paper, same as previous figure but 200µm spot

Notice the expected improvement relative to the previous figure in coupling for longer pulses by using the larger illumination diameter. By ablating material from a larger area, burnthrough is delayed.





Figire AII.6 [ID8,29] Phenolic Resin, 5μm spot.

The 280-grit paper gave our second-highest coupling coefficient. It is the binder, rather than the grit, that is providing the ablation. 3-M Corp was unable to identify the composition of the binder, other than "phenolic resin". Because ablation made blisters rather than cavities, we were unable to determine O*.

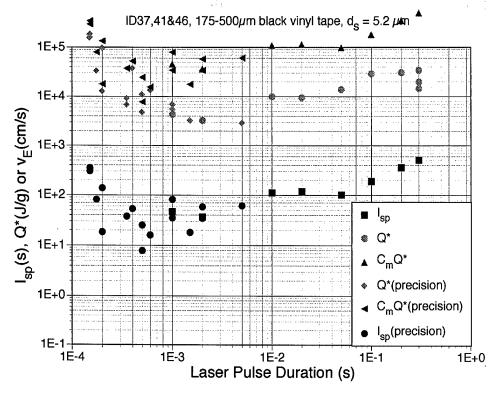


Figure AII.7 [ID37,41 & 46]

Q* data for black PVC film, 175-500μm thick, 5μm spot

This data matches the C_m plot immediately following.

 I_{sp} values are relatively high.

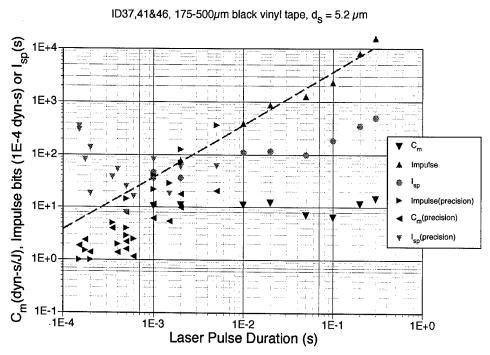


Figure AII.8 [ID37,41 & 46]

C_m data for black PVC film, 175-500 μ m thick, 5 μ m spot

Same data as Figure 14 of the main text. Note how as fluence (proportional pulsewidth) increases, coupling at first decreases because of localized burnthrough, then becomes indistinguishable from data [Figure AII.8] for a 200µm spot because of the "wings" on the laser's spacial irradiance distribution.



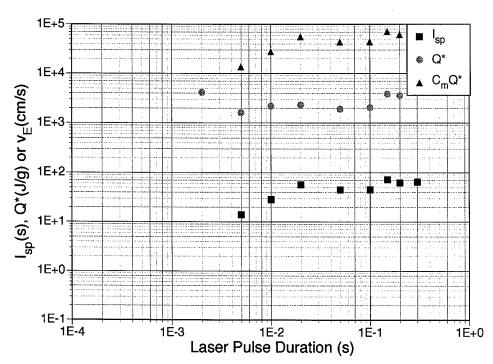
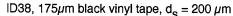


Figure AII.9 [ID 38] Q^* data for black PVC film, 175 μ m thick with 200 μ m spot.

 I_{sp} values are quite low with the larger spo size.



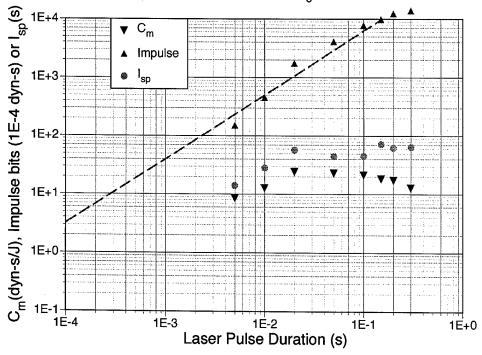


Figure AII.10 [ID38] C_m data for black PVC film, 175 μm thick with 200 μm spot.

Coupling coefficient is the largest we saw in the test series, but Q^* and I_{sp} are low.

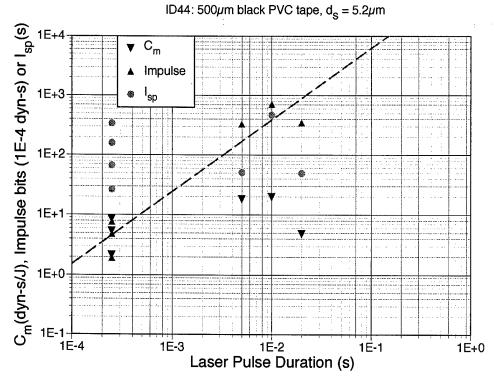


Figure AII.11 [ID44] $500-\mu m$ thick PVC film, $5\mu m$ spot.

Again, large C_m but modest Q^* .

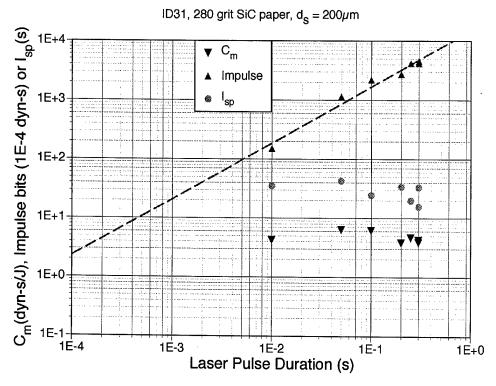


Figure AII.12[ID31] Phenolic resin, same as Figure AII.6 but 200µm spot.

Lower coupling, poor I_{sp}.

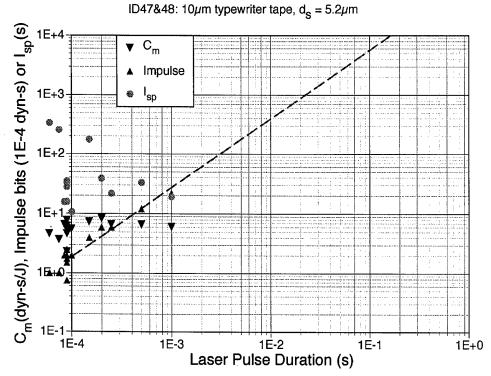


Figure AII.13 [ID47&48]

Black ink coating (est. $2\mu m$) on $10\mu m$ mylar film substrate, $5\mu m$ spot.

Same data as Figure 17 of main text.

 I_{sp} is the best we observed for 100 μ s pulses on any target.

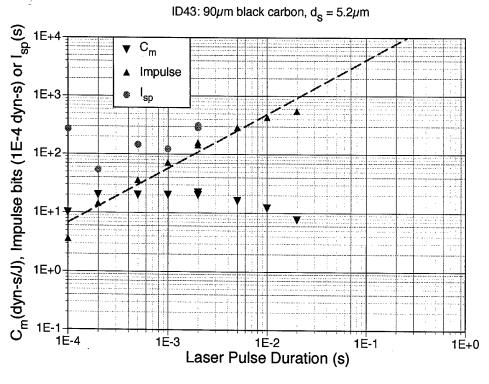


Figure AII.14 [ID48]

Thick black ink coating (90µm) on glass substrate, 5µm spot.

We dissolved the ink from the material in Figure AII.13 and applied it as a thick paste to see how coupling would survive for longer pulses. As expected, we got very good coupling near 1ms pulsewidth. I_{sp} was disappointing.

Compare Figure AII.18.

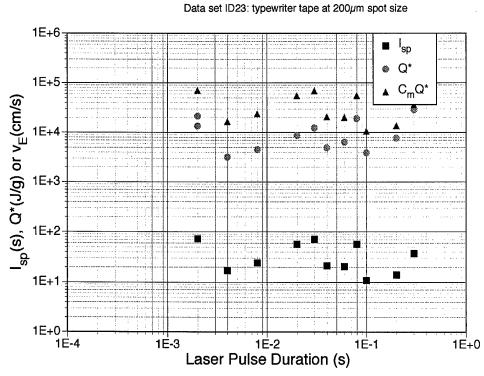
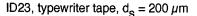


Figure AII.15 [ID23] Q* data for black ink on mylar film, 200μm spot.

As expected, I_{sp} is very poor with the larger spot and the very thin absorbing coating.



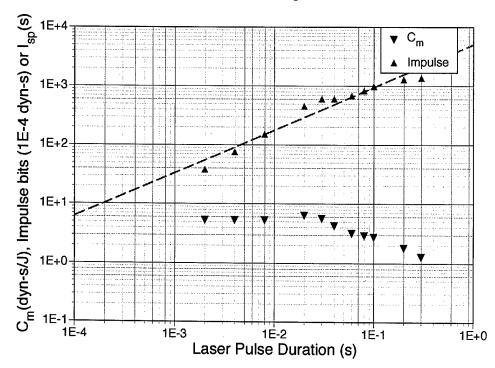
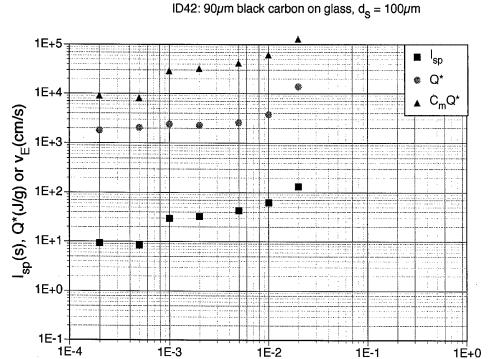


Figure AII.16 [ID23]

C_m data for black ink on mylar film, $200\mu m \ spot.$

This is an excellent target for short pulses and small impulses. It is essentially the same material as Figure 15 of the main report.

This is a classic case of rapidly degrading coupling with increasing pulse duration because a thin absorbing coating (5-10µm) overlies either a highly transparent substrate. Burnthrough occurs at 10ms.



Laser Pulse Duration (s)

Figure AII.17 [ID42]

 Q^* data for $90\mu m$ thick ink coating on glass, same target as Figure AII.14 but $100\mu m$ spot.

Uninspiring I_{sp} values are seen.

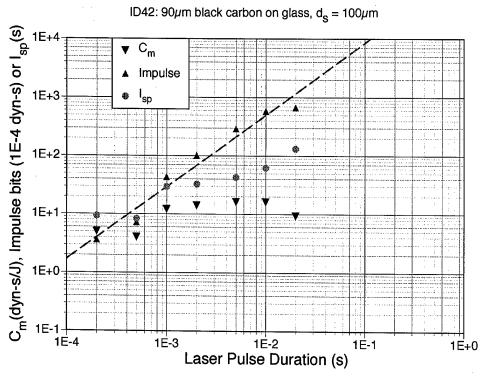


Figure AII.18 [ID42]

 C_m data for 90 μ m-thick ink coating on glass, same target as Figure AII.17.

As expected, coupling peaks at 10ms rather than 1ms [see figure AII.14] because of the larger illumination spot. Good coupling, poor I_{sp}.

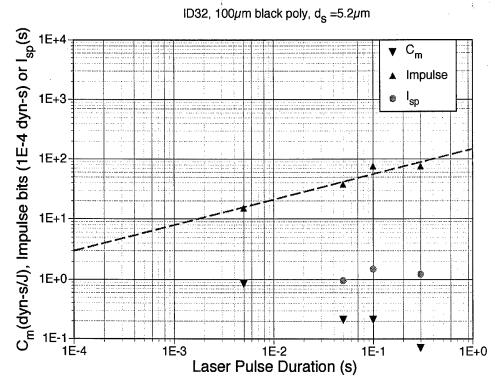


Figure AII.19 [ID32] 100µm thick black polyethylene

This data and that following shows that some materials will not couple well at the intensities we have available, even if they are highly absorptive.

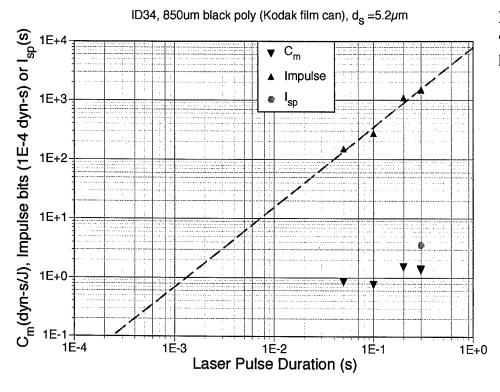
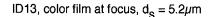


Figure AII.20 [ID34] Thick (850μm) black polyethylene



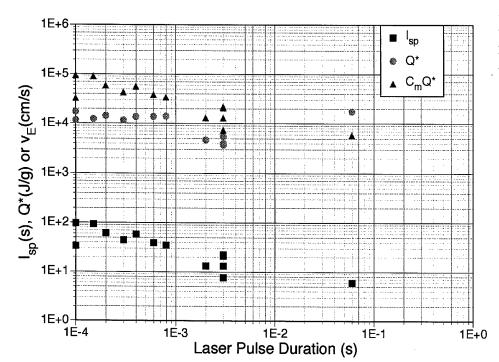


Figure AII.21 [ID13]

Q* data for undeveloped color film, emulsion side up, 5µm spot

ID13, color film, $d_S = 5.2 \mu m$

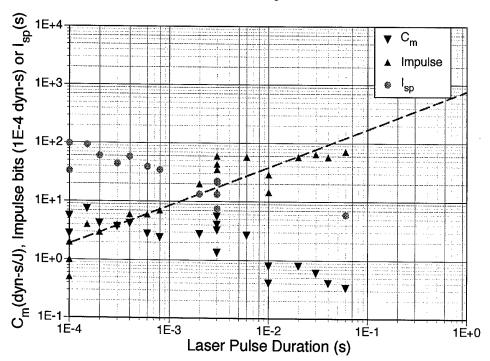


Figure AII.22 [ID13]

Q* data for undeveloped color film, emulsion side up, 5µm spot

This is yet another classic case of rapidly degrading coupling with increasing pulse duration because of a thin absorbing coating (5-10µm) overlying a transparent substrate

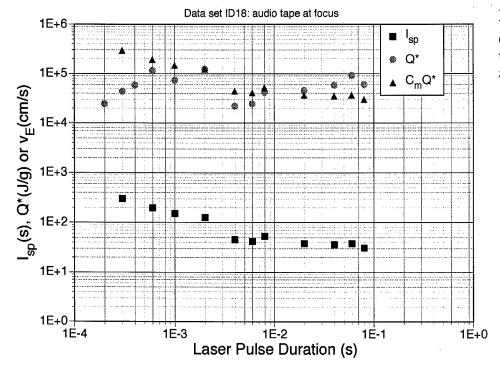


Figure AII.23 [ID18] Q* data for magnetic tape, emulsion side up, 5µm spot

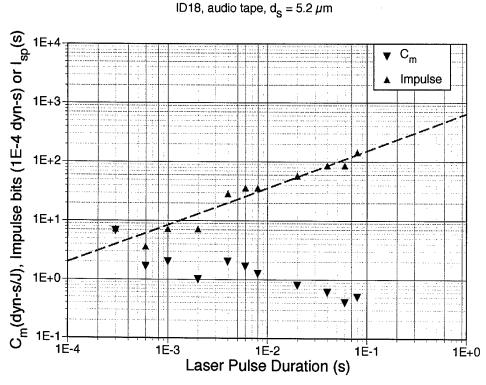


Figure AII.24 [ID18]

 C_m data for magnetic tape, emulsion side up, $5\mu m$ spot

Same basic behavior as for Figure AII.21 material.

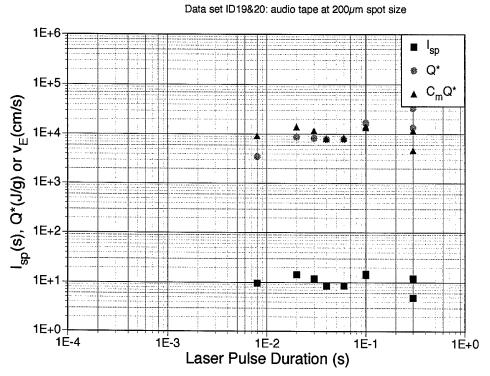


Figure AII.25 [ID19&20]

Q* data for magnetic tape, emulsion side up, 200µm spot

 I_{sp} is very poor for all pulse durations tested.

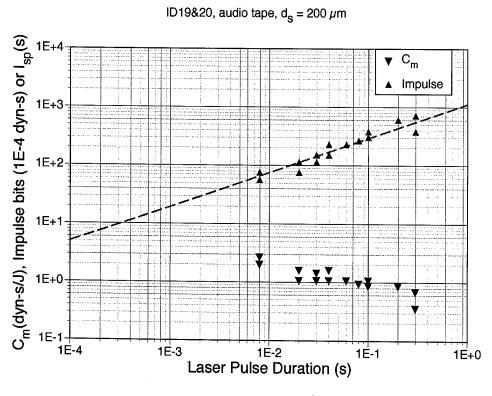


Figure AII.26 [ID19&20]

C_m data for magnetic tape, emulsion side up, $200\mu m\ spot$

C_m is very poor for all pulse durations tested.

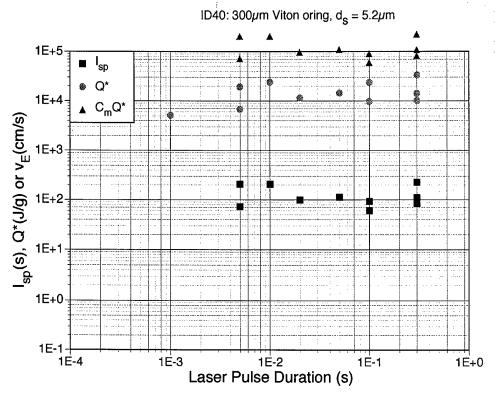


Figure AII.27 [ID40] Q* data for 900μm Viton slab, 5μm spot

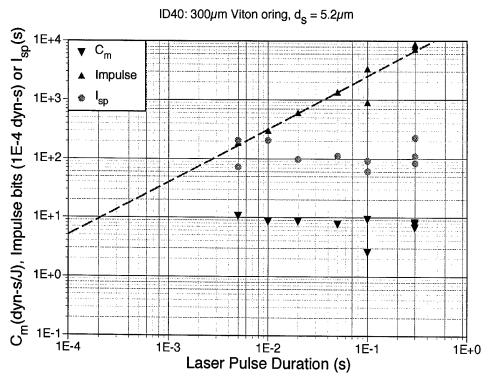


Figure AII.28 [ID40] C_m data 900 μm Viton slab, 5 μm spot

 $\begin{array}{lll} \text{Coupling} & \text{is} & \text{reasonably} \\ \text{good,} & \text{but} & I_{sp} & \text{is} \\ \text{disappointing.} & & \end{array}$

Data Set ID10: Se-black Al foil 5.2 µm spot

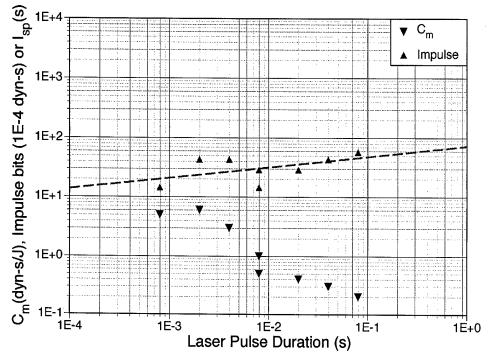


Figure AII.29 [ID10]

Bare 2024 aluminum coated with est. $1\mu m$ "selenium black" process coating.

A classic case of rapidly degrading coupling with increasing pulse duration because of a thin absorbing coating overlying a highly reflective substrate.

ID11, black sharpie on saran, $d_S = 5.2 \,\mu\mathrm{m}$

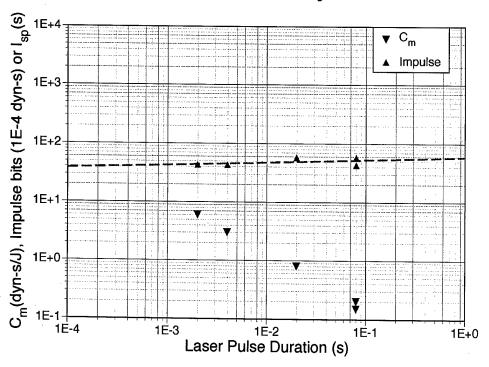


Figure AII.30 [ID11]

Vinyl copolymer ("Saran" wrap) coated with black marking ink, est. 2µm.

One final case of rapidly degrading coupling with increasing pulse duration because of a thin absorbing coating overlying a highly transparent substrate

Outgassing

We operated at typical chamber pressures of 5E-4 torr. All targets reported survived substantial vacuum exposure without any noticeable degradation of mechanical properties or performance. The ablation process did not increase chamber pressure measurably.

Annex III: Laser Momentum Coupling

Table AI.1: Glossary

Symbol	<u>Definition</u>	Value or Equivalence
α	Intensity absorption coefficient for light at the laser frequency in the absorption zone	cm ⁻¹
α_{IB}	Inverse bremsstrahlung absorption coefficient	cm ⁻¹
C _m	coupling coefficient	dyn-s/J
C_p	Specific heat at constant pressure	Jg ⁻¹ K ⁻¹
cs	Sound speed in the plume near the laser absorption zone	cm/s
C_{v}	Specific heat at constant volume	Jg ⁻¹ K ⁻¹
ds	Laser 1/e ² beam diameter at the surface	cm
Е	Substitute for "10^", for ease of reading exponents	
η_{AB}	Ablation energetic efficiency	
ε	Plasma dielectric function	
€	Emissivity	
F	Constant	2.5E4
Φ	Per-pulse laser fluence incident on the target surface	J/cm ²
g	Acceleration of gravity	980 cm/s ²
γ	C_p/C_v , 5/3 for an ideal gas and 1.2 for ablation vapor	
H	$Am_p[q^*+C_v(T-T_1)]$, total energy content	J/atom
I_{sp}	Specific impulse	S
k	Boltzmann constant	1.38E-16 erg/K
κ	$K/(\rho C_v)$, thermal diffusivity	cm ² /s
I	Laser intensity	W/cm ²
K	Thermal conductivity	Jcm ⁻¹ K ⁻¹
λ	Laser wavelength	cm
m	Constant	0.45
M_A	Average atomic mass number in ablation vapor	amu
ñ	Plasma refractive index	
n	Real part of $\tilde{\mathbf{n}}$	
n _o	Neutral density	cm ⁻³
n _j	Density of species j (electrons, ions, etc.)	cm ⁻³
$\nu_{\rm r}$	Plasma recombination rate	cm ⁻³ s ⁻¹
p	Impulse	dyne-s
Q*	Observed laser energy invested per gram of target ablated	J/g

q*	$q_f+q_v+C_vT_v$, theoretical energy per gram necessary to reach the threshold of ablation, zero ablation depth limit of Q^* with perfect absorption	J/g
q_f	Heat of fusion	J/g
$q_{\rm v}$	Heat of boiling or phase explosion	J/g
q_b	$q_f + q_b$	J/g
θ_{d}	Vapor beam angle (FWHM) leaving the Knudsen layer	deg
σ_{SB}	Stefan-Boltzmann constant	5.67E-12 Wcm ⁻² K ⁻⁴
τ	Laser pulsewidth, FWHM	S
T _e	Electron temperature near surface	K
T	Surface temperature or vapor temperature near surface	K
T_1	Boiling temperature at atmospheric pressure	K
W_L	Per-pulse laser energy	J
Wi	First ionization state energy for target atoms	J
х	Distance into surface or coating thickness	cm
ΧI	Thickness of the laser absorption layer	cm
x_{T}	Thickness of the 1D-2D transition zone	cm
x _{th}	$\sqrt{(\kappa\tau)}$, thermal diffusion depth during laser pulse	cm
V _{AB}	Ablation jet velocity	cm/s
Z	Plasma ionization state	

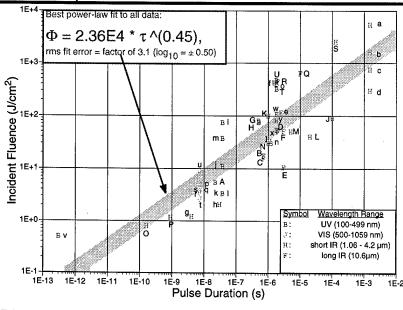


Figure AIII.1. Results of 46 Reported Experiments from the UV to the IR Show the Same Trend for the Fluence Required to Achieve Maximum Coupling. [Phipps 1996].

The momentum coupling coefficient C_m is defined as the ratio of target momentum $m\Delta v$ produced by photoablation to incident laser pulse energy W, by convention expressed in mixed units:

$$C_m = \frac{p}{W_L}$$
 dyne-s/J. [AIII.1]

As incident pulsed laser fluence increases past threshold, C_m for a wide variety of materials rises rapidly to a peak value of 2–8 dyne-s/J, declining slowly for higher fluence as ejecta velocity increases. We surveyed the results of 46 experiments in which the fluence Φ_{opt} for optimum coupling was measured, and determined that

for a wide variety of possible debris surfaces, wavelengths ranging from 0.25 to 10.6 μ m, and pulsewidths 100ps< τ <1ms, Φ_{opt} can be fit by:

$$\Phi_{\text{opt}} = F \tau^{\text{m}}$$
 [AIII.2]

Experimentally, $m \approx 0.45$, whereas thermal transient theory [Carslaw & Jaeger 1959] would give m = 0.5.

Model above plasma threshold

The basis of this portion of our model is standard plasma physics.

Defining
$$\tilde{\mathbf{n}} = \mathbf{n} + i\boldsymbol{\chi}$$
 [AIII.3]

for the plasma complex refractive index and

$$\varepsilon = \widetilde{\mathbf{n}}^2 = (\mathbf{n}^2 - \chi^2) + i \ 2 \mathbf{n} \chi$$
 [AIII.4]

as the plasma complex dielectric function, the real (refractive) and imaginary (absorptive) parts of the dielectric constant, ε , of a nonmagnetized plasma are given by

$$Re(\varepsilon) = \mathbf{n}^2 - \frac{\omega_p^2}{\omega^2 (1 + v^2/\omega^2)}$$
 [AIII.5]

and

$$Im(\varepsilon) = \frac{v}{\omega} \left[\frac{\omega_p^2}{\omega^2 (1 + v^2/\omega^2)} \right]$$
 [AIII.6]

so that the optical absorption coefficient is:

$$\alpha = \frac{2\omega}{c}\chi = \frac{v}{nc} \left[\frac{\omega_p^2}{\omega^2 (1 + v^2/\omega^2)} \right] , \qquad [AIII.7]$$

$$\boldsymbol{\varepsilon} \approx \tilde{\mathbf{n}}^2 \approx [1 - n_e/n_{ec}].$$
 [AIII.8]

When collisions are small compared to the optical frequency ($v/\omega <<1$) as is usually true for laser-produced plasma, the refractive index goes to zero and complete reflection occurs at the "critical electron density"

$$n_{ec} = m_e n^2 \omega^2 / 4\pi e^2 = 1.115 \text{ E} 21 / \lambda_{um}^2$$
 cm⁻³. [AIII.9]

Applying these results to opaque materials in vacuum irradiated by pulsed lasers at or <u>above plasma threshold</u> intensity (Phipps *et al.* 1988), gives pressure, temperature and coupling coefficient C_m to good accuracy for a broad range of irradiation conditions [Phipps *et al.* 1988].

The principal results of that work which we use here are:

$$p_{AB} = 5.83 \quad \frac{\Psi^{9/16}}{A^{1/8}} \frac{I^{3/4}}{(\lambda \sqrt{\tau})^{1/4}}$$
 dyn/cm² [AIII.10]

and

$$T_e = 2.98 \times 10^4 \frac{A^{1/8} Z^{3/4}}{(Z+1)^{5/8}} (I \lambda \sqrt{\tau})^{1/2}$$
 K [AIII.11]

for the plasma electron temperature where $2\Psi = A/[(Z^2(Z+1)]^{1/3}]$, and $\Psi \le 1$ for nearly every case with the longer pulses in this project. For coupling coefficient we have:

$$C_{\rm m} = 3.95 \ {\rm M_A}^{0.44}/[{\rm Z}^{0.38}({\rm Z}+1)^{0.19}({\rm I}\lambda\sqrt{\tau})^{0.25}].$$
 [AIII.12]

Model below plasma threshold

Below plasma threshold, in the vapor-dominated regime, C_m can be calculated via a Clausius-Clapeyron relation:

$$p(atm) = \frac{p}{p_1} = exp\left[\frac{H_1}{kT_1} - \frac{H}{kT}\right]$$
 [AIII.13]

Eqn. [AIII.6] may be rewritten in a simpler form with temperature T as a free variable:

$$\ln p(atm) = \frac{M_A}{k} \left[\left(\frac{q^*}{T_1} - C_v \right) + \left(\frac{C_v T_1 - q^*}{T} \right) \right]$$
 [AIII.14]

The following relationship connects laser intensity I to the material variables:

$$I = \rho v_{AB}[q^* + C_p(T_{vapor} - T_1) + v_{AB}^2/2] + (x_{skin} + x_{th})\rho_s C_v(T_1 - T_0)/\tau + \epsilon \sigma_{SB}T^4.$$
 [AIII.15]

Taking the five terms in sequence, these energy sinks are 1) providing the vaporization energy q^* to an element of vapor, 2) further heating the vapor after it leaves the surface, 3) accelerating the vapor, 4) heating a final element of surface of thickness $(x_{skin} + x_{th})$ to temperature T_0 which is left behind without vaporization at the end of the laser pulse, and 5) black body emission with emissivity \in from the half-plane facing the laser.

If we now let $p_{vap} = p$, $T_{vap} = T$, and vary T, the result can then be presented as a plot of p vs. I for a target material with a chosen laser pulsewidth, from which the vapor phase value of C_m can be obtained [Figure AIII.2].

The crossover between these regimes in our model is smooth, showing that both predictions are good in their respective limits.

General considerations

Two other quantities which are often used to describe laser ablation and laser propulsion are Q^{\ast} , the incident laser energy (J/g) required to ablate unit mass of target material, and I_{sp} (s), familiar from rocketry as specific impulse. It is important to realize that the two elements of the pairs (C_m , Q^{\ast}) and (C_m , I_{sp}) are not independent, but increasing one decreases the other.

$$C_{m}Q^{*} = v_{E} = gI_{sp}, [AIII.16]$$

and
$$C_m I_{sp} = C_m^2 Q^*/g = 20,394 \eta_{AB}$$
, [AIII.17]

where v_E is the exhaust velocity of the ablation jet. Eqn. [AIII.17] permits I_{sp} for laser ablation jets

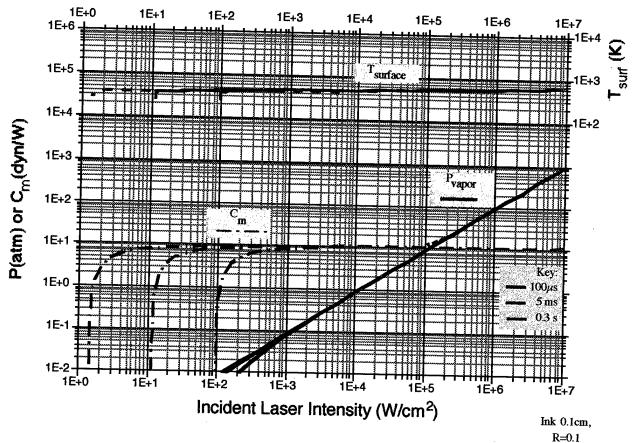


Figure AIII.2: Surface pressure, temperature and coupling coefficient C_m predicted by our model, vs. incident laser intensity for black ink and pulse duration = 100μ s, 5ms & 300ms.

to achieve values much larger than those available in chemical reactions. Experimental results as large as 7,000 seconds have been achieved in other reported work [Phipps et al. 1994].

Figure AIII.2 shows good agreement with results we measured from the type of targets we have used in this STTR project, in which the laser absorbing surface is black ink and the substrate has low thermal diffusivity (paper, mylar, etc.). Note that the <u>surface</u> temperature in the Figure AIII.2 simulation is just that - the temperature of the solid/vapor interface at the ablating surface.

Above plasma threshold in the vapor, surface temperature would not be much different, but laser heating of the vapor continues until temperatures of 10,000 - 20,000K are achieved.

This model (described above) shows no transition to plasma regime at the largest intensities we achieved with our 1-W laser. Other considerations, treated in Annex V, enter into determining where this transition occurs.

Practically speaking, it is easy to obtain $C_m = 10$ dyne-s/J [1E-4 n-s/J] from the ink-like target materials we have studied for a 1-dimensional interaction, and possible to obtain $C_m = 20-25$, given spot size much smaller than the target, so that the laser-induced pressure wave expands across the target until it dissipates. We regard agreement with our simulations as very good.

References

Campbell, J. W., NASA Marshall Spaceflight Center Technical Memorandum 108522 (1996) Carslaw, H.S. and Jaeger, J.C. 1959 Conductin of Heat in Solids Clarendon, Oxford Phipps, C.R. and Michaelis, M.M. 1994, "LISP," *Laser and Particle Beams*, 12 (1), 23-54 Phipps, C. R., AIP Conf. Proceedings 318 pp. 466-8 (1993)

Phipps, C.R., Harrison, R.F., Shimada, T., York, G.W., Turner, T.P., Corlis, X.F., Steele, H.S., Haynes L.C. and King, T.R. 1990, "Enhanced Vacuum Laser-impulse Coupling by Volume Absorption at Infrared Wavelengths", *Laser and Particle Beams*, **8**, 281

Phipps, C.R., Turner, T.P., Harrison, R.F., York, G.W., Osborne, W.Z., Anderson, G.K., Corlis, X.F., Haynes, L.C., Steele, H.S., Spicochi, K.C., and King, T.R. 1988, "Impulse Coupling to Targets in Vacuum by KrF, HF and CO2 Lasers", J. Appl. Phys., 64, 1083

Annex IV: Average Fluence

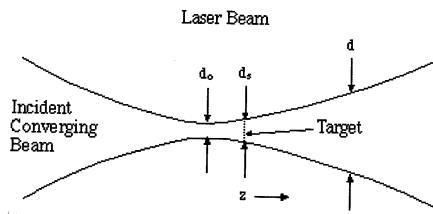


Figure AI.1: Illustrating parameters of analysis

shots we deliberately chose $d_{s\,1} >> d_o$, say 200 μ m instead of 5μ m, to obtain data for coupling for a range of fluence as well as pulsewidth. In such a case, the variation might be less severe. With so many variables, we needed an analytical method of determining the fluence variation during a pulse.

Taking

$$\begin{split} &<\Phi>=\frac{1}{\tau}\int_{0}^{\tau}dt\;\Phi(t)\\ &=\frac{4\,W_{L}}{\pi\,\tau}\int_{0}^{\tau}\frac{dt}{d^{2}(t)}\qquad [AIV.1]\\ &d^{2}(t)=d_{o}^{2}+\left(\sqrt{d_{s}^{2}-d_{o}^{2}}+\frac{z}{f_{\#}}\right)^{2}\quad [AIV.3]\\ &d_{1}=\sqrt{d_{s}^{2}-d_{o}^{2}}\qquad [AIV.4]\\ &<\Phi>\\ &=\frac{4\,W_{L}\,f_{\#}^{2}}{\pi\,\tau}\int_{0}^{\tau}\frac{dt}{\left(f_{\#}\,d_{1}+z\right)^{2}+\left(f_{\#}d_{o}\right)^{2}} \end{split}$$

Table AI.1: Glossary

With the lightweight pendulum, target acceleration leads substantial target motion during the longer laser pulses. It was important to be able to correct data when this variation was slight, as well to indicate when it was necessary to use the heavy pendulum to get meaningful measurement of C_m vs. fluence in a given case.

Further, in about half the

	Glossaly	
Sym -bol	<u>Definition</u>	Value or equivalence
C_{m}	coupling coefficient	dyn-s/J
d_{s1}	Starting spot size	cm
d_{s2}	Ending spot size	cm
d_0	Minimum spot size	cm
Е	Fiber Young's modulus	7.08E11 dyn/cm ²
f#	Illumination f-number	(f/d _s)
f	Illumination focal length	cm
Φ	Laser fluence on target	J/cm ²
m	Effective mass at radius R	gm
n/m	not measured	
p	Impulse	dyn-s
θ	Rotation angle	rad
$\theta_{\rm o}$	Rotation amplitude	rad
R	Impulse moment arm	2 cm
τ	Pulse duration	S
W_L	Incident laser energy	J
$\omega_{\rm o}$	Resonant frequency	2πf _o rad/s

where

$$C = \frac{4 W_L f_\#^2}{\pi \tau}$$
 and

[AIV.5]

 $= C \int_0^{\tau} \frac{dt}{(\alpha + \beta t^2)^2 + \gamma^2}$

$$\gamma = f_{\#}d_{o}$$

[AIV.6]

$$\alpha = f_{\#} d_{_{\rm I}} \qquad \qquad \text{and} \qquad \qquad \beta = \frac{\omega_{_{\! o}} \theta_{_{\! o}} R}{2 \, \tau} \qquad \qquad \text{[AIV.7]}$$

and we have taken

$$z = \frac{\ddot{z} t^2}{2}$$
 and $\ddot{z} = \frac{\omega_o \theta_o R}{\tau}$. [AIV.8]

The integral AIV.5 is tabulated [Gradshteyn & Ryzhik 1965] and the result is:

$$\langle \Phi \rangle = \frac{C}{4 \, \beta^2 \, q^3 \sin \psi} *$$

$$\left[\sin(\psi/2)\ln\left(\frac{t^2+2 q t \cos(\psi/2)+q^2}{t^2-2 q t \cos(\psi/2)+q^2}\right)+2\cos(\psi/2)\tan^{-1}\left(\frac{t^2-q^2}{2q t \sin(\psi/2)}\right)\right] \qquad [AIV.9]$$

with notations
$$\Psi = \cos^{-1}\left[-1/\sqrt{[1+(\gamma/\alpha)^2]}\right]$$
 and $q^2 = \frac{\sqrt{\alpha^2 + \gamma^2}}{\beta}$ [AIV.10]

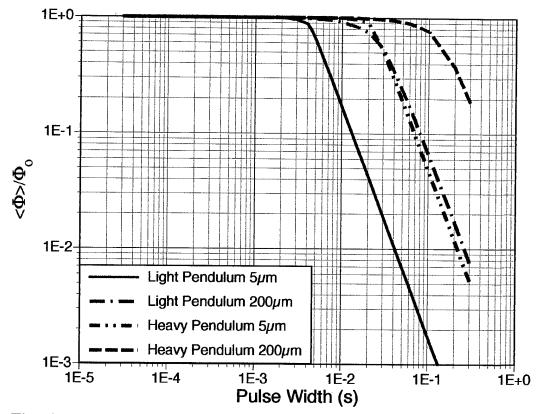


Figure AIV.1: How target motion during laser pulse affects average fluence for the two pendula and two initial spot sizes

Reference

1. Gradshteyn, I. S. and Ryzhik, I. M.(1965), Table of Integrals, Series and Products, Academic, New York § 2.161.1b

Target Matrix

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Table AIV.1. Maximum Values of Average Fluence

				Pe	Pend.	Pulse width	se Ith	Φ	Φ̄	
Test Nos	Target	d _s (μμ)	t (μm)	Lt	Hvy	Min (ms)	Max (ms)	$\frac{\mathrm{Max}}{\mathrm{J/cm}^2}$	Gold Bar <u>J/cm</u> ²	$\overline{\Phi}_{0}/\overline{\Phi}_{\mathrm{g}}$
4,12	Black printer's ink:paper	5	350	X		0.1	40	1.70E+3	5.54E+3	0.307
30	Black printer's ink:paper	5	350		×	100	300	3.12E3	1.37E+4	0.228
9	Black printer's ink:paper	100	350	×		8.0	09	3.40E+2	6.65E+3	0.051
7	Black printer's ink:paper	200	350	×		0.2	50	4.30E+1	6.13E+3	0.007
21,22	Black printer's ink:paper	700	350		×	10	300	3.64E+2	1.37E+4	0.027
9,16	Xerographic black:paper	2	100	×		0.1	08	4.64E+3	7.57E+3	0.613
24	Xerographic black:paper	200	100		×	5	300	1.50E+2	1.37E+4	0.011
41,46	Thin PVC film	5	175	×		0.1	5	3.55E+3	2.17E+3	1.632
37	Thin PVC film	5	175		×		300	8.55E+3	1.37E+4	0.623
38	Thin PVC film	200	175		X	2	300	8.90E+1	1.37E+4	900.0
44	Thick PVC film	5	200	X		0.1	20	2.20E+3	4.06E+3 (0.542
	Phenolic resin	5	250	×		8.0	100	5.56E+3	8.37E+3 (0.664
29	Phenolic resin	5	250		×	2	300		1.37E+4	
31	Phenolic resin	200	250		×	10	300	1.53E+2	1.37E+4 (0.011
47,48	Black ink: mylar	5	20	×		0.05	T	3.13E+2	1.05E+3 (0.297
23	Black ink: mylar	200	50		×	2	300	2.30E+2	1.37E+4 (0.017
25	Black ink: mylar sandwich	200	100	:	×	-	300	2.30E+2	1.37E+4 0	0.017

Nos Salaci				rei	Pend.	width	lth_	କା	∌	
	Target	d _s	t (μm)	Lt	Hvy	Min (ms)	Max (ms)	$\frac{Max}{I/cm^2}$	Gold Bar <u>J/cm²</u>	$\overline{\Phi}^{ m o}/\overline{\Phi}^{ m g}$
	Black ink:glass	5	06	X		0.1	20	1.35E+3	4.06E+3	0.333
1	Black ink:glass	100	96	×		0.1	20	4.70E+1	4.06E+3	0.012
32 Blacl polye	Black thin polyethylene	5	100		×	₹.	300	6.50E+4	1.37E+4	4.735
34 Blacl	Black thick polyethylene	Ŋ	850		×	50	300	2.00E+4	1.37E+4	1.457
45 Kapton	ton	5	125	×		0.2	200	6.50E+3	1.14E+4	0.568
13 Phot	Photographic film	5	175	×		0.1	09	8.54E+3	6.65E+3	1.283
18 Audi	Audio tape	5	50	×		0.1	08	7.90E+3	7.57E+3	1.043
19,20 Audi	Audio tape	200	50	×	×	∞	300	3.00E+2	1.37E+4	0.022
26 Grap	Graphite sheet	5	380		×	100	300	2.00E+4	1.37E+4	1.457
40 Viton	ů	5	300		X	1	300	4.80E+4	1.37E+4	3.496
10 Se bl	Se black: Al	5	100	×		8.0	80	4.05E+4	7.57E+3	5.017
11 Blac copo	Black ink:vinyl copolymer	5	25	X		8.0	80	4.05E+4	7.57E+3	5.348
33 Cellu	Cellulose nitrate	5	0/		×	2	300	9.24E+4	1.37E+4	6.733
39 Blac	Black anodize:Al	5	200		X	2	300	9.24E+4	1.37E+4	6.733
36 Fiber	Fiberglas	5	1500		X	2	300	9.24E+4	1.37E+4	6.733

The Table, adapted from Table AII.1, compares the maximum average fluence values achieved in all data sets with the "gold bar" predictions of Figures 10 of the report and Figure AIII.1. We were not able to exceed the "gold bar" values by very much with the 1-watt laser. These data are also plotted in the Figure following.

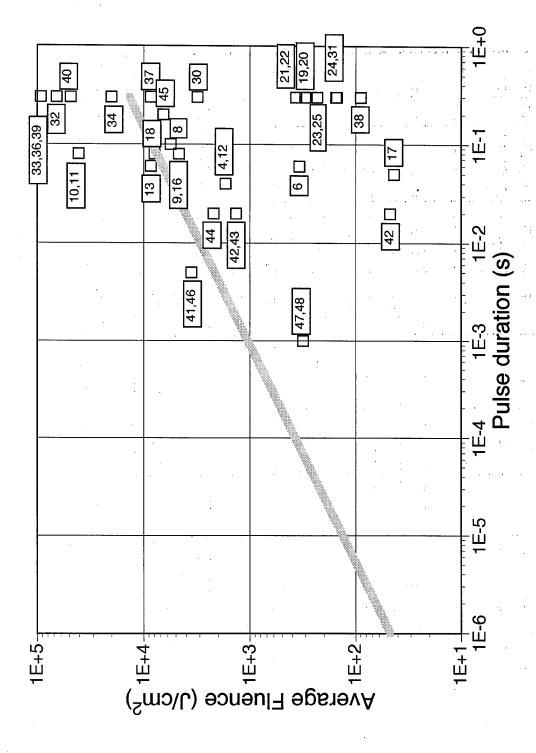


Figure AIV.2. Maximum averge fluence for all data sets [boxes] values achieved vs. "Gold Bar" values

Those targets which we subjected to the highest average fluence were, with one exception, the most refractory, generating zero or very small impulse: polyethylene, fiberglas, bare aluminum, aluminum with a thin selenium-black process coating and vinyl copolymer (saran wrap). The exception is viton, data set 40, which generated reasonably good coupling.

Annex V: Plasma Parameters [objectives f, g]

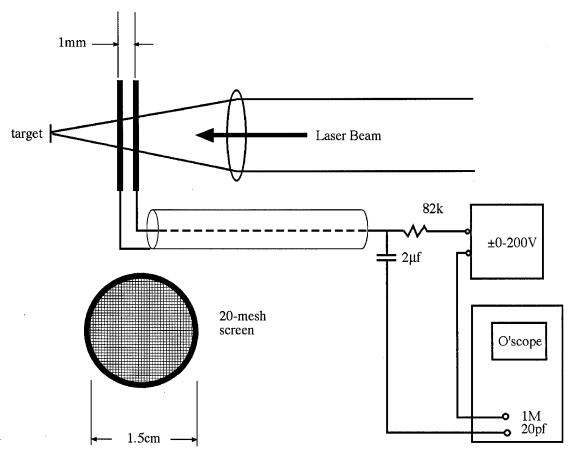


Figure V.1. Plasma Detector

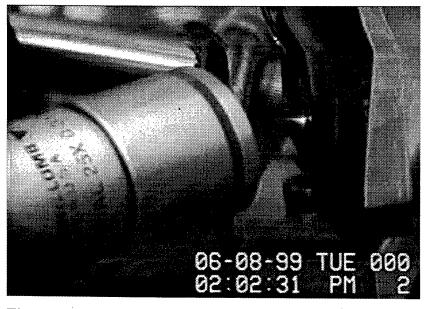


Figure V.2. [obective. g] The LPT jet is seen (at the focus of the 25X microscope objective). The polar distribution of the plume occupyies less than 0.005 sterrad.

Plasma detector

We built an efficient plasma detector [Figure V.1] with a coarse screen that permitted it to be inserted directly in the beam without degrading the focus significantly. The result was negative during the time available for study of plasma formation.

Analysis: Our negative result is not due to the situation λ_{en} >> d_s. From the point of view of laser-induced ionization avalanche, the region near the target still looks 1-dimensional, small though it is. Instead, it is due to the much greater importance of lateral and axial thermal conduction for 5 μ m spots, together with relatively long

Table V.1. Plasma Test parameters	
Solid angle subtended	1 sterrad
Pulse duration τ	20 ms
Signal V	<10mV
Signal Current I	<120nA = 7.5 E11
	e ⁻ /s
Target	PVC film
Ablation volume (by inspection)	67 μcm ³ /shot
No. of atoms ablated	1.1E16/shot
Ablation rate R	5.5E17/s
Predicted plume temperature	0.1 eV
Predicted plume velocity v _{thi}	9.0E4 cm/s
Plume cone angle (full)	20 degrees
Plume density near detector n _{od}	2.8E13 cm ⁻³
Ionization fraction $\eta_i = I/R$	<1.4E-6
Plasma density near detector n _{ed}	< 3.8E7 cm ⁻³
Plume density at target n _{oT}	2.8E19 cm ⁻³
Neutral cross-section σ	5E-15 cm ²
Electron-neutral mean free path at target $\lambda_{en} = 1/(n_{oT}\sigma)$	0.07µm
Electron Debye screening distance at detector $\lambda_{Ded} = 745 [T_{e(eV)}/n_{ed}]^{1/2}$	>380μm
Electron plasma frequency near detector $v_{ped} = 8978(n_{ed})^{1/2}$	<55MHz

pulses. Table V.2 above quantifies this point.

In the absence of plasma, further effort on the plasma topic was not warranted.

2. Optical diagnostics

Optical diagnostics consisted of a magnified view of the plume recorded with a high performance video camera.

Table V.2. Comparing thermal diffusion distance to d_s=5µm for two pulse durations and several materials

Epoxy Epoxy Epoxy 1.15 0.000124 1.11E-4 Epoxy d 1.184 0.000394 1.98E-4 1.184 0.000394 1.98E-4 1.184 0.000806 2.84E-4 1.184 0.000806 2.84E-4 1.184 0.000970 3.08E-4 1.185 1.213 1.439 0.000974 3.12E-4 rene 1.6E-3 1.088 1.080 0.001360 3.69E-4 rene 2.2E-3 1.213 1.190 0.001360 3.69E-4 re acetate 2.2E-3 1.213 1.190 0.001520 3.90E-4 rene 2.2E-3 1.213 1.190 0.001520 3.90E-4 rene 0.9E-3 0.863 3.0 0.008400 9.17E-4 rene 0.16 1.088 2.4 0.061300 2.48E-3 restricte 0.34 0.134 11.342 0.224000 4.00E-3 Phenolic 0.34 0.134 11.342 0.24000 4.97E-3 reatbide 0.84 0.668 2.33 0.540000 7.35E-3 run alloys 2000 2.0 0.962 2.70 0.7785000 8.86E-3 run ium	<u>Material</u>	K	C	đ	K (cm ² /s)	$\overline{\mathbf{x}}_{1\text{th}}(100\mu s)$	x_{1th}/d_s	$\underline{\mathbf{x}}_{2th}(300\mathrm{ms})$	x_{2th}/d_s
idene chloride (saran) 9.2E-4 1.339 1.744 0.000394 1.98E-4 1.45poxy r Epoxy loid loid 1.18-3 1.213 1.439 0.000950 3.08E-4 1.08E-4 1.08E-4 1.08E-4 1.08B 1.080 0.001360 3.08E-4 1.08E-4 1.08B 1.080 0.001360 3.09E-4 1.08E-4 1.08B 1.080 0.001360 3.09E-4 1.08E-4 1.08E-4 1.08B 1.080 0.001360 3.09E-4 1.08E-3 1.08E-3 1.08B 1.080 0.001360 3.09E-4 1.0E-3 1.08E-3 1.08B 1.080 0.001360 3.00E-4 1.0E-3 1.08E-3	PMMA			1.15	0.000124	1.11E-4	2.22E-1	6.10E-3	1.22E+1
tr Epoxy 1.184 0.000806 2.84E-4 loid 1.321 0.000950 3.08E-4 loid 1.7E-3 1.213 0.000974 3.12E-4 tyrene 1.6E-3 1.088 1.080 0.001360 3.69E-4 tyrene 1.6E-3 1.088 1.080 0.001360 3.69E-4 lose acetate 3.3E-3 1.757 1.329 0.001410 3.75E-4 loce acetate 3.3E-3 1.757 1.329 0.001410 3.75E-4 loce acetate 2.2E-3 1.213 1.190 0.001520 3.90E-4 loce acetate 2.2E-3 1.213 1.190 0.001520 3.90E-4 loce acetate 6.9E-3 0.863 2.4 0.002500 2.1E-4 lain 0.16 1.088 2.4 0.004300 2.1E-3 loss Steel 0.23 0.460 6.809 0.073400 4.00E-3 lond benolic 0.88 0.234 15.223 0.247000 4.97E-3	Vinylidene chloride (saran)	9.2E-4	1.339	1.744	0.000394	1.98E-4	3.96E-1	1.09E-2	2.17E+1
loid 1.321 0.000950 3.08E-4 tyrene 1.7E-3 1.213 1.439 0.000974 3.12E-4 lose acetate 1.6E-3 1.088 1.080 0.001360 3.69E-4 ic 2.2E-3 1.757 1.329 0.001410 3.75E-4 ic 2.2E-3 1.213 1.190 0.001520 3.90E-4 ic 2.2E-3 1.213 1.190 0.001520 3.90E-4 ic 2.2E-3 1.213 1.190 0.001520 3.90E-4 ic 6.9E-3 0.863 3.0 0.002670 5.17E-4 lain 0.16 1.088 2.4 0.061300 2.48E-3 less Steel 0.23 0.460 6.809 0.073400 4.0BE-3 nn Phenolic 0.34 0.134 11.342 0.224000 4.73E-3 nn 0.88 0.234 15.223 0.240000 7.35E-3 nn 0.84 0.668 2.33 0.540000 4.97E-3	Kevlar Epoxy			1.184	0.000806	2.84E-4	5.68E-1	1.55E-2	3.11E+1
tyrene 1.7E-3 1.213 1.439 0.000974 3.12E-4 lose acetate 3.3E-3 1.088 1.080 0.001360 3.69E-4 lose acetate 3.3E-3 1.757 1.329 0.001410 3.75E-4 i.c c.zE-3 1.213 1.190 0.001520 3.90E-4 i.c c.zE-3 1.213 1.190 0.001520 3.90E-4 lain 0.16 1.088 2.4 0.002670 5.17E-4 lain 0.16 1.088 2.4 0.061300 2.48E-3 less Steel 0.23 0.460 6.809 0.073400 2.71E-3 less Steel 0.34 0.134 11.342 0.224000 4.00E-3 less on 0.88 0.234 15.223 0.247000 4.97E-3 linum alloys 2000 2.0 0.962 2.70 0.770000 8.77E-3 lesium 1.40 1.025 1.74 0.785000 8.86E-3 lesium 1.40 1.025 1.74 0.785000 1.07E-2	Celluloid			1.321	0.000050	3.08E-4	6.16E-1	1.69E-2	3.38E+1
tyrene 1.6E-3 1.088 1.080 0.001360 3.69E-4 lose acetate 3.3E-3 1.757 1.329 0.001410 3.75E-4 ic 2.2E-3 1.213 1.190 0.001520 3.90E-4 ic 6.9E-3 0.863 3.0 0.002670 5.17E-4 lain 0.16 1.088 2.2 0.008400 9.17E-4 lain 0.16 1.088 2.4 0.061300 2.48E-3 less Steel 0.23 0.460 6.809 0.073400 2.71E-3 on Phenolic 0.34 0.134 11.342 0.224000 4.06-3 n 0.34 0.134 11.342 0.247000 4.97E-3 n 0.88 0.234 15.223 0.54000 7.35E-3 n 0.84 0.668 2.33 0.54000 7.35E-3 inum alloys 2000 2.0 0.962 2.70 0.77000 1.07E-3 cesium 1.40 1.025 1.74	PVC	1.7E-3	1.213	1.439	0.000974	3.12E-4	6.24E-1	1.71E-2	3.42E+1
lose acetate 3.3E-3 1.757 1.329 0.001410 3.75E-4 ic 2.2E-3 1.213 1.190 0.001520 3.90E-4 ic 2.2E-3 1.213 1.190 0.001520 3.90E-4 less 6.9E-3 0.863 3.0 0.002670 5.17E-4 lain 0.16 1.088 2.4 0.008400 9.17E-4 less Steel 0.23 0.460 6.809 0.073400 2.48E-3 on Phenolic 0.23 0.460 6.809 0.073400 2.71E-3 ten carbide 0.88 0.234 11.342 0.224000 4.97E-3 on 0.88 0.234 15.223 0.247000 4.97E-3 inum alloys 2000 2.0 0.962 2.70 0.770000 8.77E-3 esium 1.40 1.025 1.74 0.785000 1.07E-3	Polystyrene	1.6E-3	1.088	1.080	0.001360	3.69E-4	7.38E-1	2.02E-2	4.04E+1
ic 2.2E-3 1.213 1.190 0.001520 3.90E-4 lain 0.16 1.088 2.4 0.061300 2.48E-3 less Steel 0.23 0.460 6.809 0.073400 2.71E-3 ten carbide 0.34 0.134 11.342 0.247000 4.73E-3 num alloys 2000 2.0 0.962 2.70 0.770000 8.77E-3 essium 1.40 1.025 1.74 0.785000 8.86E-3 essium 2.2E-3 1.213 1.190 0.001520 3.90E-4 1.432 0.001340 2.71E-3 1.432 0.247000 4.73E-3 1.432 0.547000 7.35E-3 esium 1.40 1.025 1.74 0.785000 8.86E-3	Cellulose acetate	3.3E-3	1.757	1.329	0.001410	3.75E-4	7.50E-I	2.06E-2	4.11E+1
lain 6.9E-3 0.863 3.0 0.002670 5.17E-4 lain 0.16 1.088 2.4 0.061300 2.48E-3 less Steel 0.23 0.460 6.809 0.073400 2.71E-3 on Phenolic 0.34 0.134 11.342 0.160000 4.03E-3 ten carbide 0.88 0.234 15.223 0.24000 4.73E-3 on 0.84 0.668 2.33 0.54000 7.35E-3 inum alloys 2000 2.0 0.962 2.70 0.770000 8.77E-3 esium 1.40 1.025 1.74 0.785000 8.86E-3	Acrylic	2.2E-3	1.213	1.190	0.001520	3.90E-4	7.80E-1	2.14E-2	4.27E+1
ain 0.16 1.088 2.4 0.061300 2.48E-3 ess Steel 0.23 0.460 6.809 0.073400 2.71E-3 n Phenolic 1.432 0.160000 4.00E-3 en carbide 0.34 0.134 11.342 0.224000 4.73E-3 en carbide 0.88 0.234 15.223 0.247000 4.97E-3 n 0.84 0.668 2.33 0.540000 7.35E-3 num alloys 2000 2.0 0.962 2.70 0.770000 8.86E-3 esium 1.40 1.025 1.74 0.785000 1.07E-2	Mica	6.9E-3	0.863	3.0	0.002670	5.17E-4	1.03E+0	2.83E-2	5.66E+1
Steel 0.16 1.088 2.4 0.061300 2.48E-3 Steel 0.23 0.460 6.809 0.073400 2.71E-3 henolic 1.432 0.160000 4.00E-3 carbide 0.34 0.134 11.342 0.224000 4.73E-3 carbide 0.88 0.234 15.223 0.247000 4.97E-3 n alloys 2000 2.0 0.668 2.33 0.540000 7.35E-3 m 1.40 1.025 1.74 0.775000 8.86E-3	Silica			2.2	0.008400	9.17E-4	1.83E+0	5.02E-2	1.00E+2
0.23 0.460 6.809 0.073400 2.71E-3 1.432 0.160000 4.00E-3 0.34 0.134 11.342 0.224000 4.73E-3 0.88 0.234 15.223 0.247000 4.97E-3 0.84 0.668 2.33 0.540000 7.35E-3 2000 2.0 0.962 2.70 0.770000 8.77E-3 1.40 1.025 1.74 0.785000 8.86E-3	Porcelain	0.16	1.088	2.4	0.061300	2.48E-3	4.96E+0	1.36E-1	2.71E+2
0.34 0.134 11.342 0.224000 4.00E-3 0.88 0.234 15.223 0.247000 4.97E-3 0.84 0.668 2.33 0.540000 7.35E-3 2000 2.0 0.962 2.70 0.770000 8.77E-3 1.40 1.025 1.74 0.785000 8.86E-3	Stainless Steel	0.23	0.460	6.809	0.073400	2.71E-3	5.42E+0	1.48E-1	2.97E+2
0.34 0.134 11.342 0.224000 4.73E-3 0.88 0.234 15.223 0.247000 4.97E-3 0.84 0.668 2.33 0.540000 7.35E-3 2.0 0.962 2.70 0.770000 8.77E-3 1.40 1.025 1.74 0.785000 8.86E-3	Carbon Phenolic			1.432	0.160000	4.00E-3	8.00E+0	2.19E-1	4.38E+2
0.88 0.234 15.223 0.247000 4.97E-3 0.84 0.668 2.33 0.540000 7.35E-3 2.0 0.962 2.70 0.770000 8.77E-3 1.40 1.025 1.74 0.785000 8.86E-3 2.01 0.265 8.04 1.140000 1.07E-2	Lead	0.34	0.134	11.342	0.224000	4.73E-3	9.46E+0	2.59E-1	5.18E+2
0.84 0.668 2.33 0.540000 7.35E-3 2.0 0.962 2.70 0.770000 8.77E-3 1.40 1.025 1.74 0.785000 8.86E-3	tungsten carbide	0.88	0.234	15.223	0.247000	4.97E-3	9.94E+0	2.72E-1	5.44E+2
2.0 0.962 2.70 0.770000 8.77E-3 1.40 1.025 1.74 0.785000 8.86E-3	Silicon	0.84	999.0	2.33	0.540000	7.35E-3	1.47E+1	4.02E-1	8.05E+2
1.40 1.025 1.74 0.785000 8.86E-3	aluminum alloys 2000	2.0	0.962	2.70	0.770000	8.77E-3	1.75E+1	4.81E-1	9.61E+2
2 01 0 285 8 04 1 140000 1 07E-2	magnesium	1.40	1.025	1.74	0.785000	8.86E-3	1.77E+1	4.85E-1	9.71E+2
3.91 0.383 8.94 1.1140000 1.07.2-2	Copper	3.91	0.385	8.94	1.140000	1.07E-2	2.14E+1	5.85E-1	1.17E+3
graphite 1.64 0.682 1.522 1.580000 1.26E-2 2.52E+1	graphite	1.64	0.682	1.522	1.580000	1.26E-2	2.52E+1	6.88E-1	1.38E+3

Conclusion:

Good correlation is found between the condition $x_{th}/d_s < 1$ for the shortest pulses we used (italics) and ability to obtain photoablation on the types of target materials we studied.